

Canadian Powder Diffraction workshop 13

# Thin Film Characterization with X-Rays

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October 26–30, 2020

**CPDW 13**

# TOPICS

1. Motivation

2. Is the film thin?

3. X-ray Attenuation

*Techniques:*

a) GI-powder XRD

b) GI-single crystal XRD

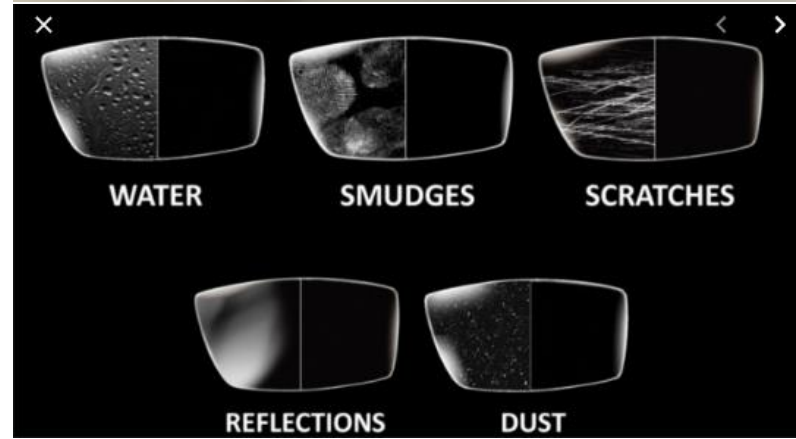
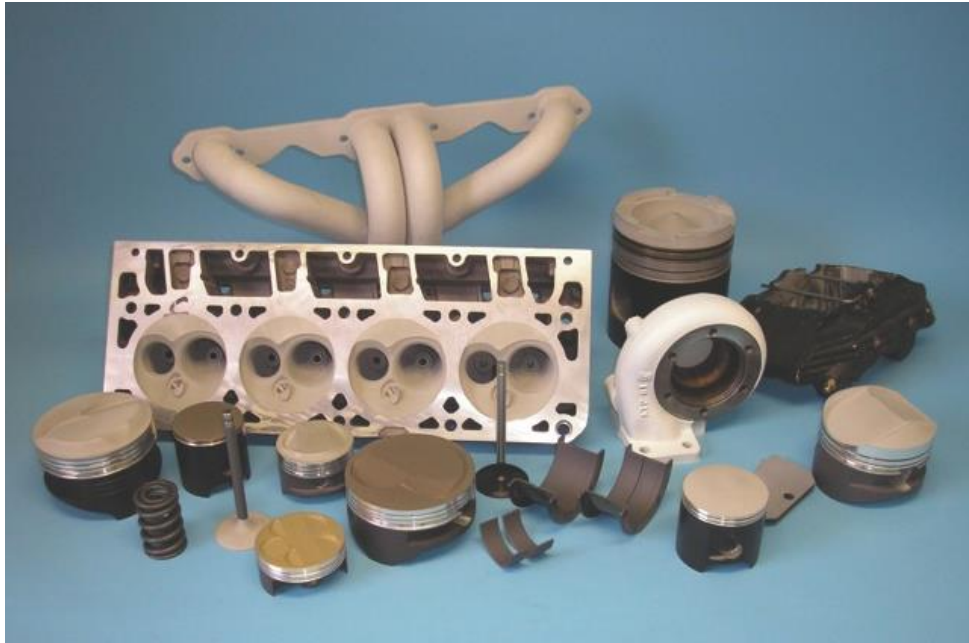
c) Reflectivity

d) GISAXS





# Motivation

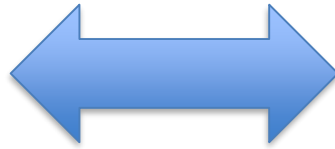


**Three Most Common  
Issues Coatings  
Address:**

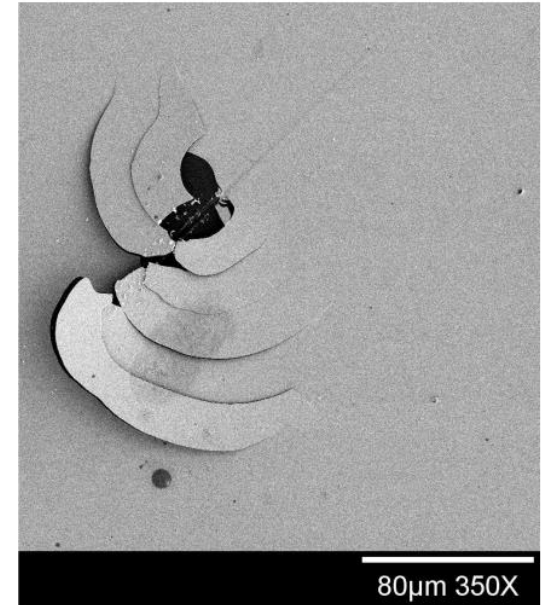
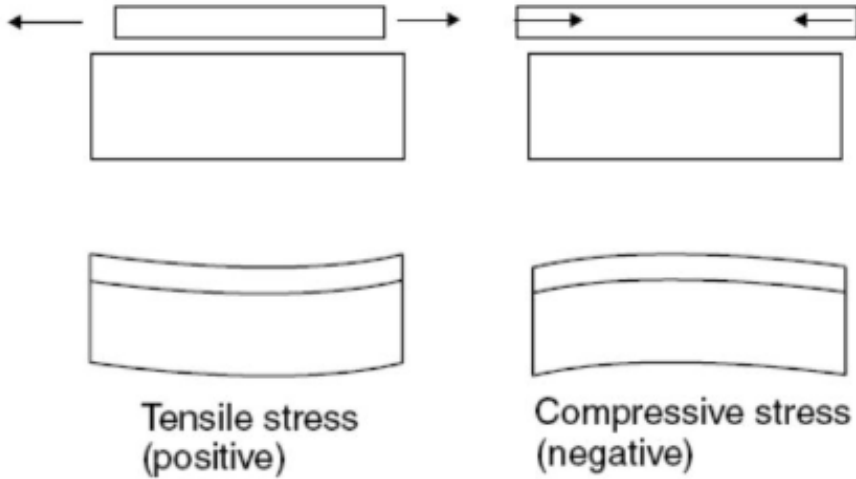
- 1. Friction**
- 2. Heat**
- 3. Corrosion**



# Structure



# Performance



Stress fracture patterns in ALD W/Si



# What can we measure?

Small angle x-ray reflectivity

GI-SAXS

GI-WAXS -- GI -- PXRD  
-- GI -- RSM

Reflectivity

XRD

Pole figures

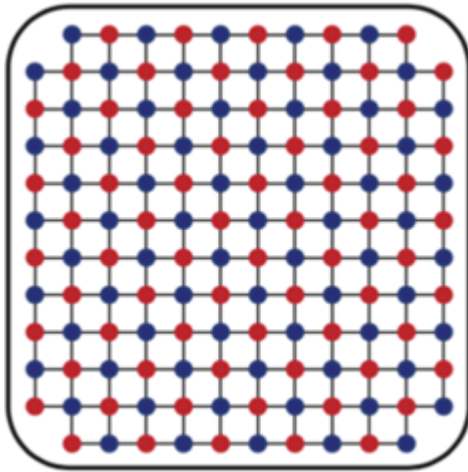
They yield information about:

- ✓ Film thickness, roughness, porosity
- ✓ Structure, stress, texture, defects
- ✓ Composition, interdiffusion, gradients
- ✓ Buried nanostructures, size, shape, ordering

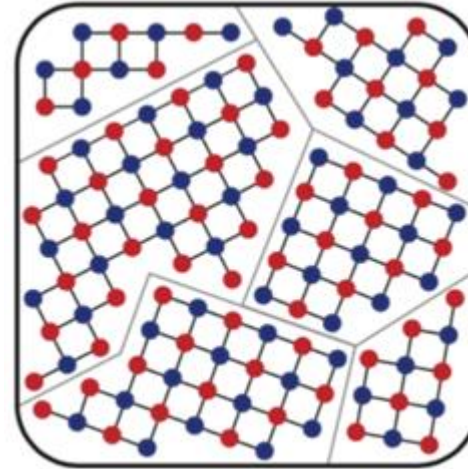


# What kind of films can we measure?

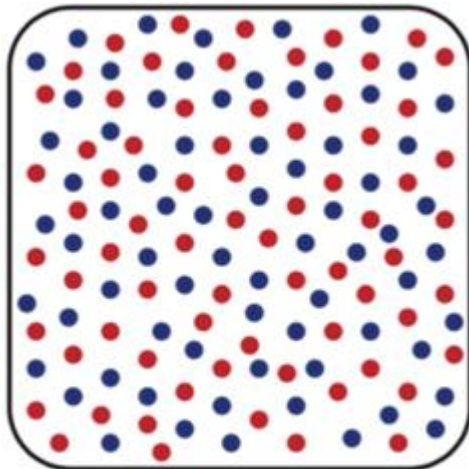
Single-crystal



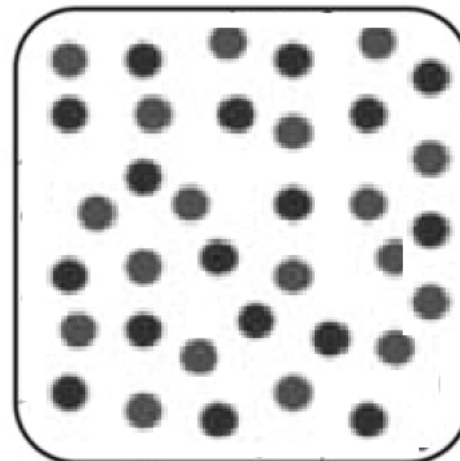
Poly-crystalline



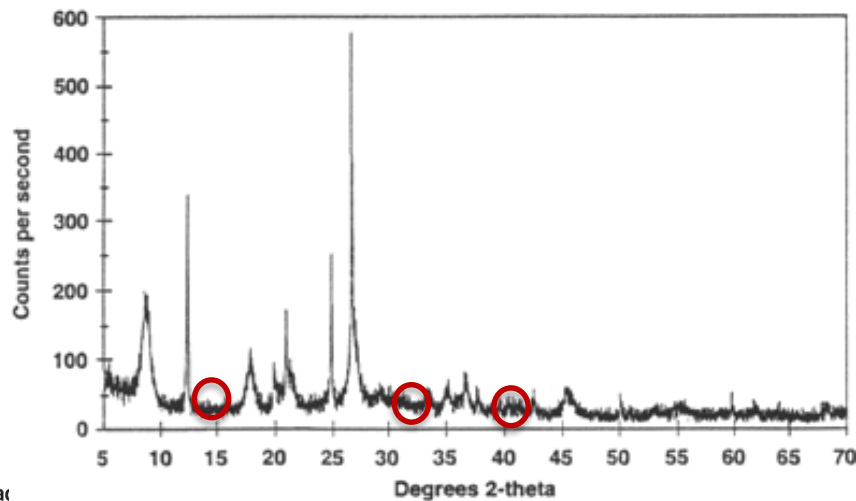
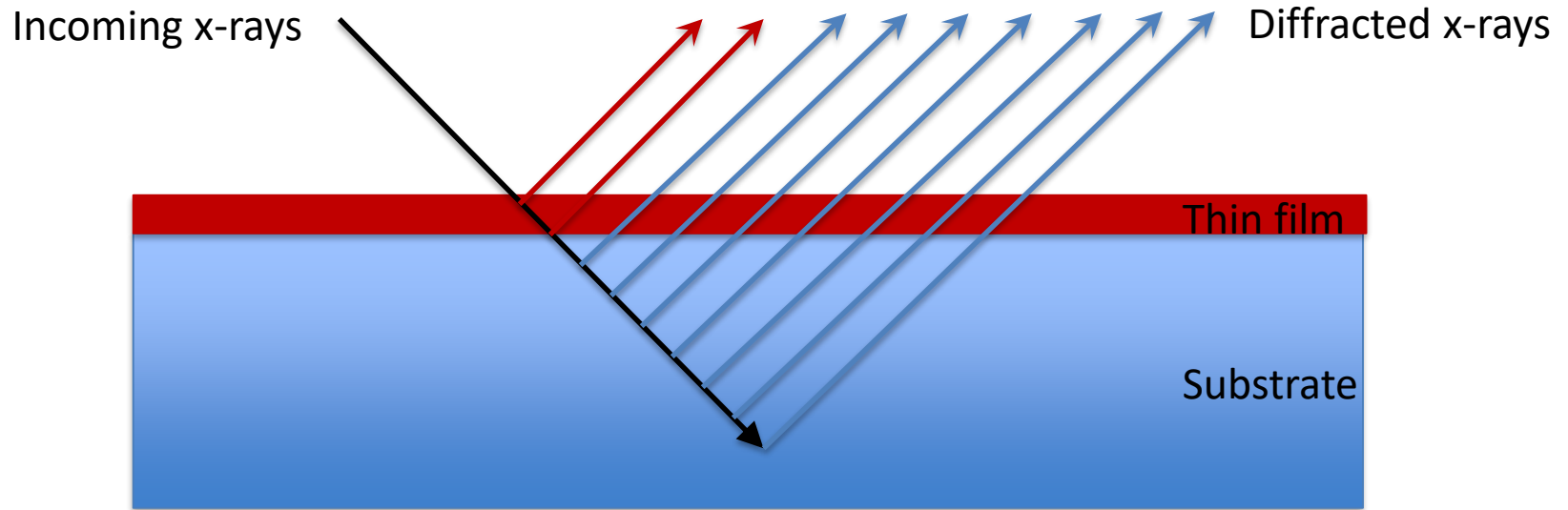
Amorphous



Nanostructures

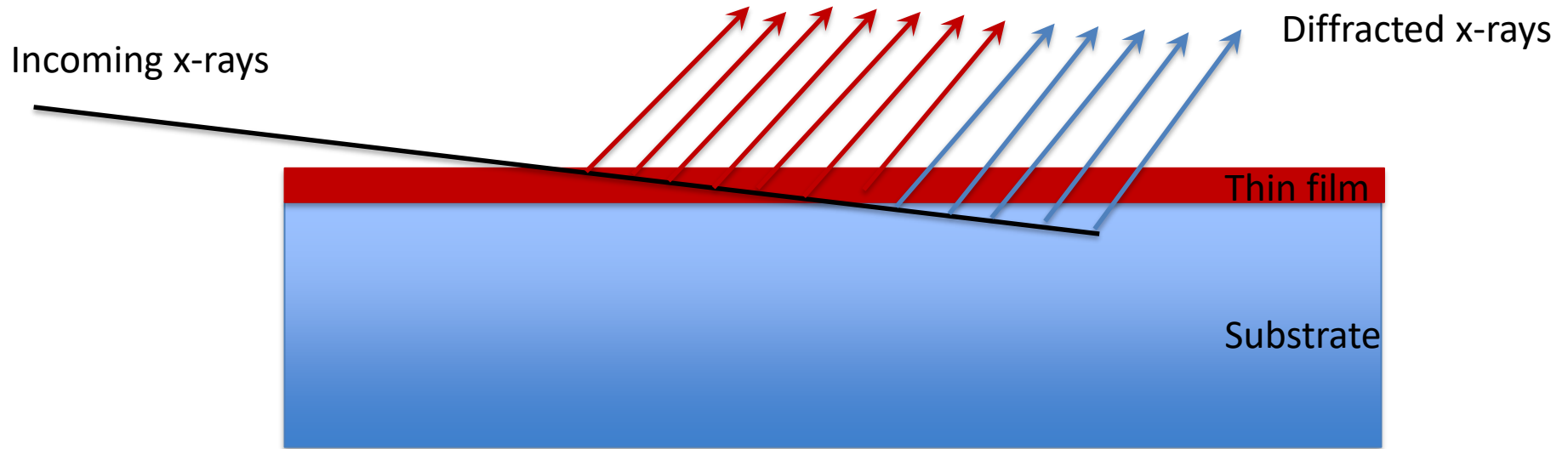


# Using X-Rays to investigate thin films





# The grazing incidence geometry enhances the film signal relative to the substrate signal





# X-Rays attenuation length

The **attenuation length**  $\varepsilon$  is the distance over which the x-ray beam intensity has dropped to  $1/e$  of its incident intensity.

$$e = 2.718281828459045$$

$$1/e = 0.367879441171$$

Denser materials will have shorter attenuation lengths.

Higher energies will have longer attenuation lengths

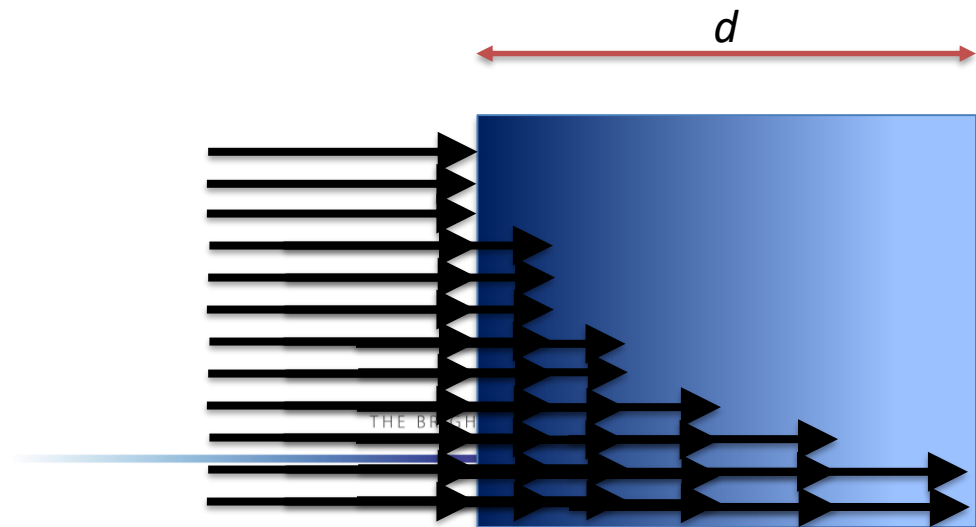
$$I = I_0 e^{-\frac{d}{\varepsilon}}$$

The **attenuation coefficient**  $\mu$  is simply the inverse of the attenuation length

$$I = I_0 e^{-\mu \cdot d}$$

Where to find attenuation lengths of materials:

- CXRO
- XOP/XPOWER
- ...





**X-Ray Database**

Nanomagnetism

X-Ray Microscopy

EUV Lithography

EUV Mask Imaging

Reflectometry

Zoneplate Lenses

Coherent Optics

Nanofabrication

Optical Coatings

Engineering

Education

Publications

Contact



The Center for X-Ray Optics is a multi-disciplined research group within Lawrence Berkeley National Laboratory's (LBNL) Materials Sciences Division (MSD). [Notice to users.](#)

# X-Ray attenuation length

## X-Ray Interactions With Matter

### Introduction

Access the [atomic scattering factor](#) files.

Look up [x-ray properties of the elements](#).

The [index of refraction](#) for a compound material.

The x-ray [attenuation length](#) of a solid.

X-ray transmission

- Of a [solid](#).
- Of a [gas](#).

X-ray reflectivity

- Of a [thick mirror](#).
- Of a [single layer](#).
- Of a [bilayer](#).
- Of a [multilayer](#).

The diffraction efficiency of a [transmission grating](#).

Related calculations:

- Synchrotron [bend magnet radiation](#).

[Other x-ray web resources.](#)

[X-ray Data Booklet](#)

# X-Ray attenuation length

## X-Ray Attenuation Length

- Choose from a list of common materials:  ▾
- Chemical Formula:
- Density:  gm/cm<sup>3</sup> (enter negative value to use tabulated values.)
- Scan  ▾ from  to  in  steps (< 500).  
(NOTE: Energies must be in the range 30 eV < E < 30,000 eV, Wavelength between 0.041 nm < Wavelength < 41 nm)
- At fixed  =

To request a  ▾  ▾ press this button:

To reset to default values, press this button: .



# X-Ray attenuation length

## X-Ray Attenuation Length

- Choose from a list of common materials:
- Chemical Formula:
- Density:  gm/cm<sup>3</sup> (enter negative)
- Scan  from   
(NOTE: Energies must be in the range 30 eV to 100,000 eV)
- At fixed  =

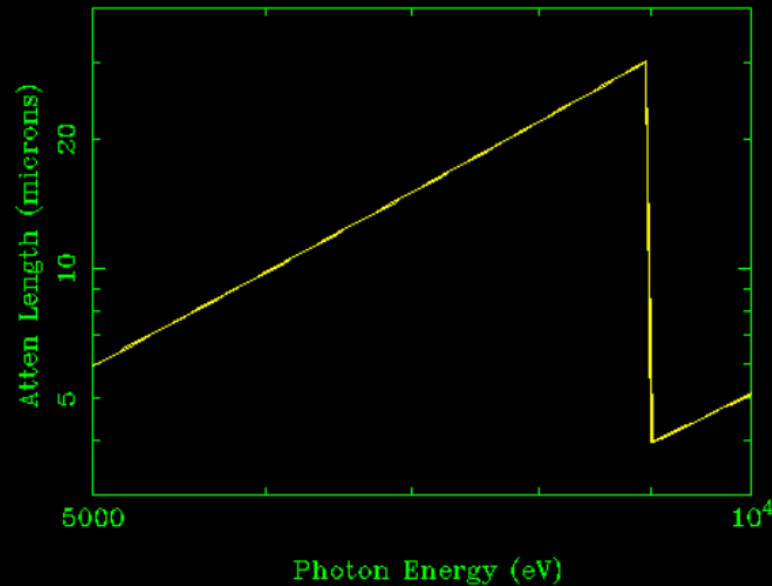
To request a   press this button:

To reset to default values, press this button:

**X-Ray Attenuation Length:** [data file here](#)

Print

Cu Density=8.96, Angle=90.deg



length < 41





# X-Ray attenuation length



X-Ray Database



Zone Plate Education



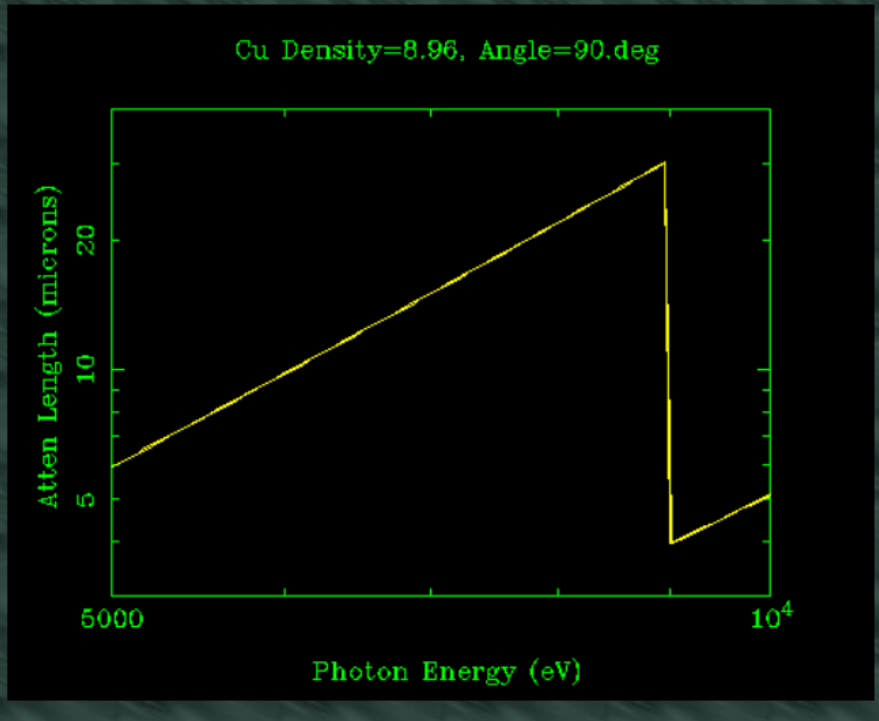
## X-Ray Attenuation

Cu Density=8.96, Angle=90.deg  
Photon Energy (eV), Atten Length (microns)

5000.00	5.96392
5034.78	6.07762
5069.80	6.19352
5105.06	6.31168
5140.57	6.43210
5176.32	6.55489
5212.33	6.68003
5248.58	6.80778
5285.09	6.93802
5321.85	7.07069
5358.87	7.20583
5396.14	7.34361
5433.67	7.48427
5471.47	7.62763
5509.53	7.77389
5547.85	7.92298
5586.44	8.07487
5625.29	8.22963
5664.42	8.38748
5703.82	8.54873
5743.49	8.71308
5783.44	8.88042
5823.67	9.05096
5864.17	9.22514

X-Ray Attenuation Length: [data file here](#)

Print



length < 41

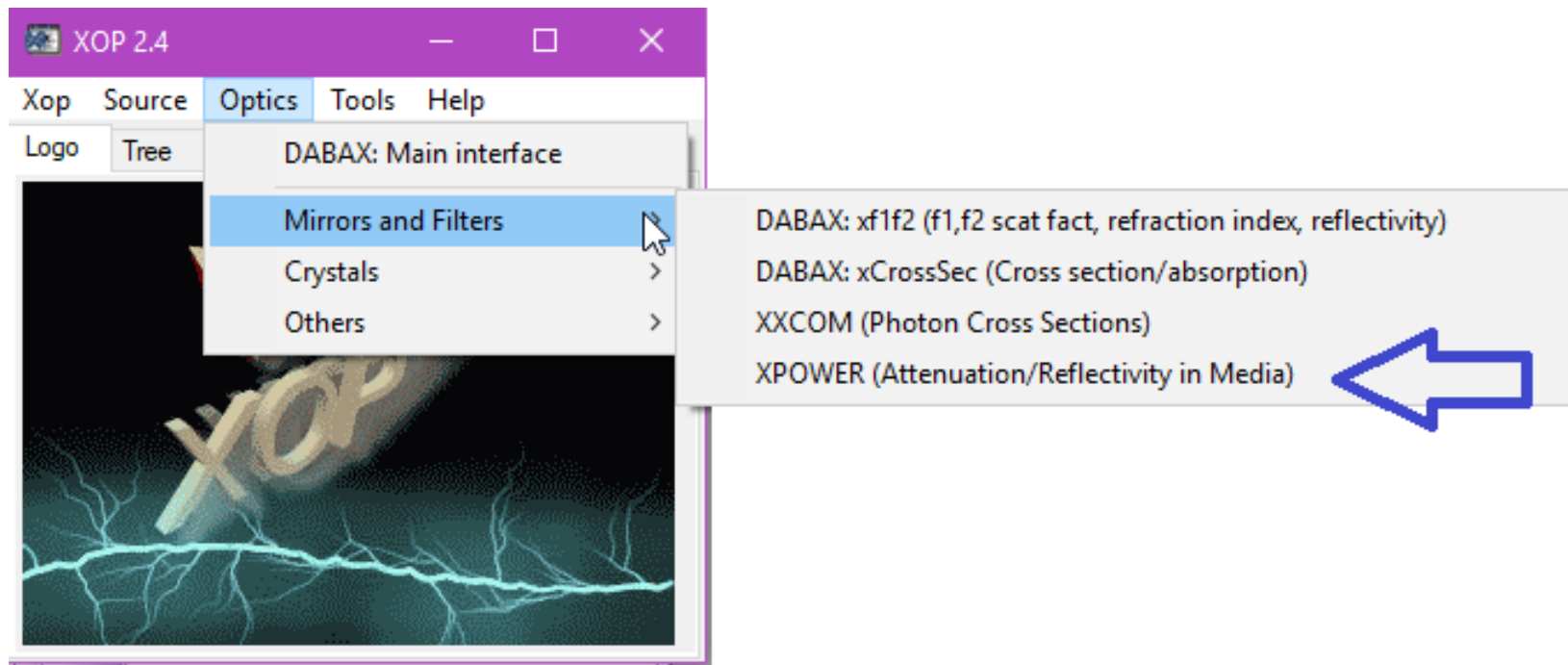
Element 29: Cu

Edge	keV
K	8.9789

# X-Ray attenuation length

## XOP/XPOWER

<https://www.aps.anl.gov/Science/Scientific-Software/XOP>



# X-Ray attenuation length

The image displays the Xpower software interface, which is used for calculating X-ray attenuation and reflectivity. The main window, titled "Xpower input data", contains several input fields for configuring the simulation. The "f1f2 dataset" is set to "f1f2\_Windt.dat", the "Mu dataset" is "CrossSec\_XCOM.dat", and the "Source" is "Normalized to 1 (E from keyboard)". The energy range is defined by "From energy [eV]: 5000.0000" and "To energy [eV]: 50000.000", with "Energy points: 100". The "Number of elements" is set to "1". The "1st oe formula" is "Cu", the "kind" is "Filter", and the "Filter thick[mm]" is "0.50000000". The "Density [g/cm^3]" is currently "?".

The "Xpower results" window shows a plot titled "Local properties of optical elements". The y-axis is labeled "[oe 1] Mu[cm^-1]" and ranges from 0 to 2500. The x-axis is labeled "Photon Energy [eV]" and ranges from 0 to 5x10^4. The plot shows a sharp peak at approximately 8512.55 eV, with a value of about 2400 cm^-1. The current cursor position is X:8512.55 Y:1607.81.

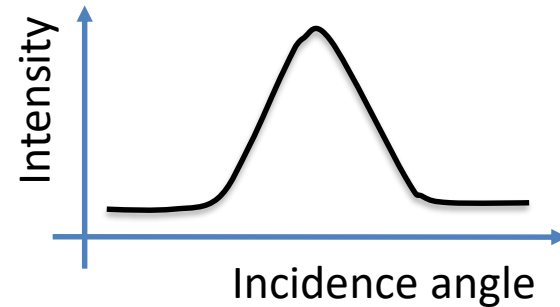
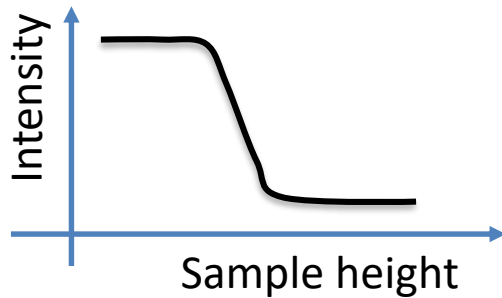
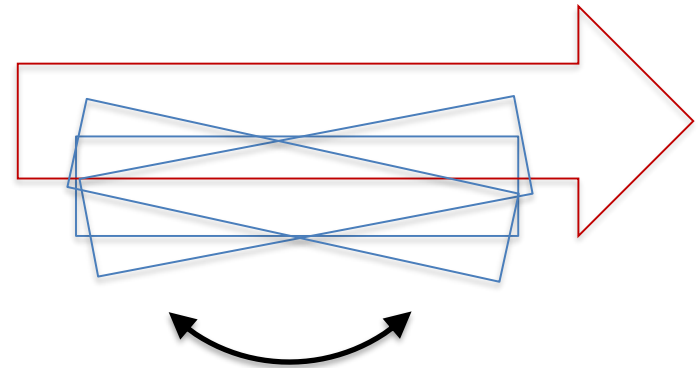
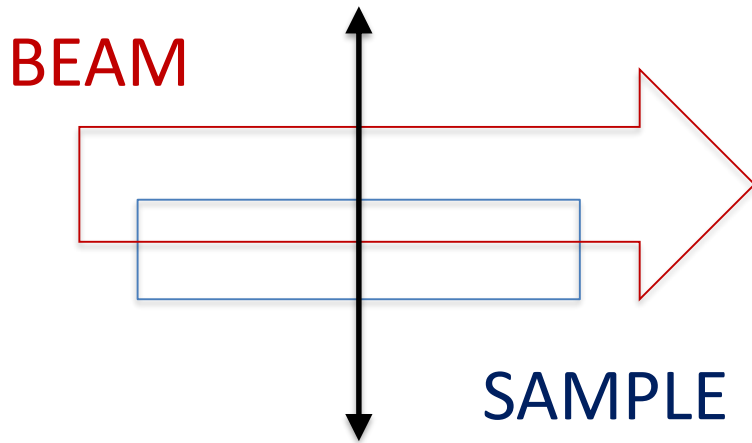
A promotional banner for Xpower is also visible, with the text: "Xpower Attenuation & reflectivity in media. Effect on source spectrum".

# How do we measure?





# Sample alignment



Iterate!



# Grazing incidence diffraction

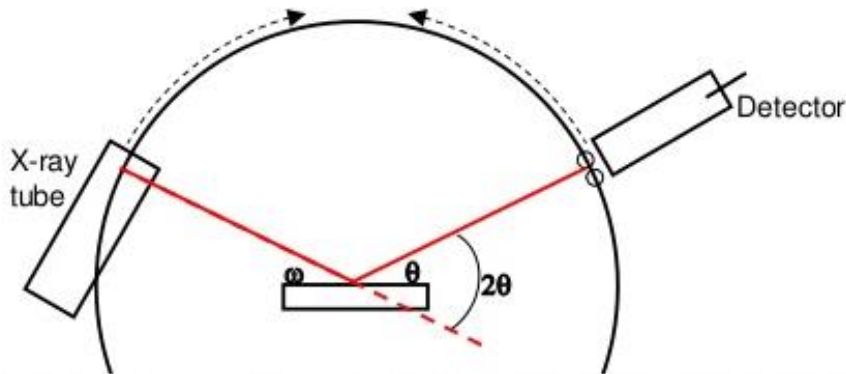
applied to

Polycrystalline films

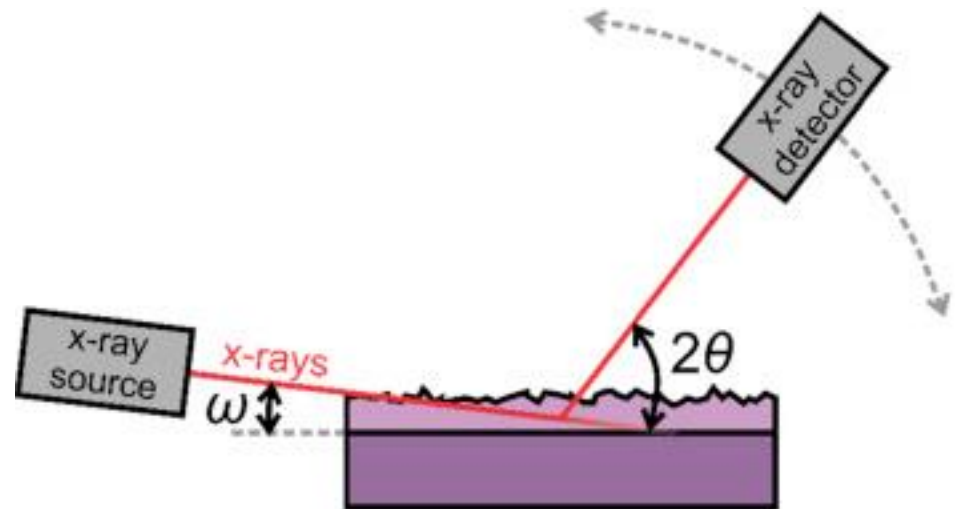


# Grazing incidence diffraction

Regular specular geometry,  $\omega = \theta$



Grazing incidence geometry

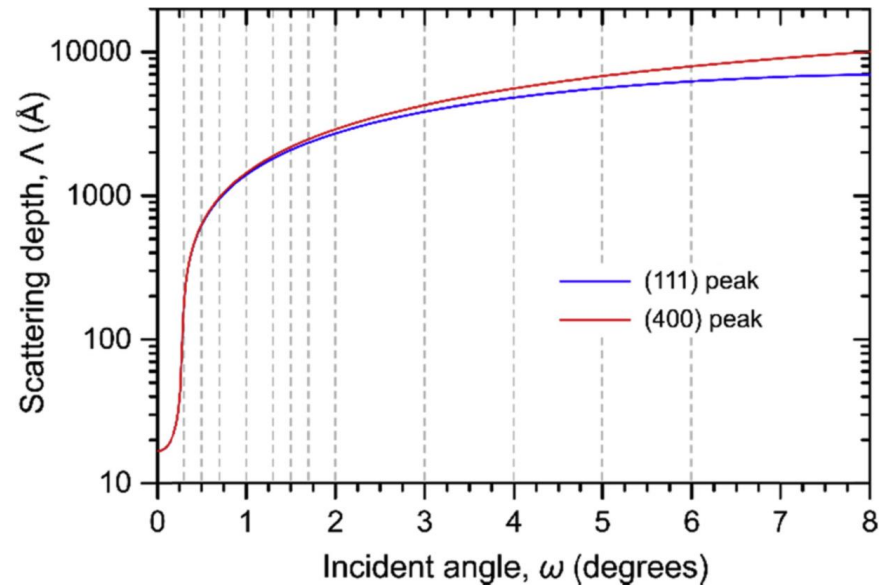
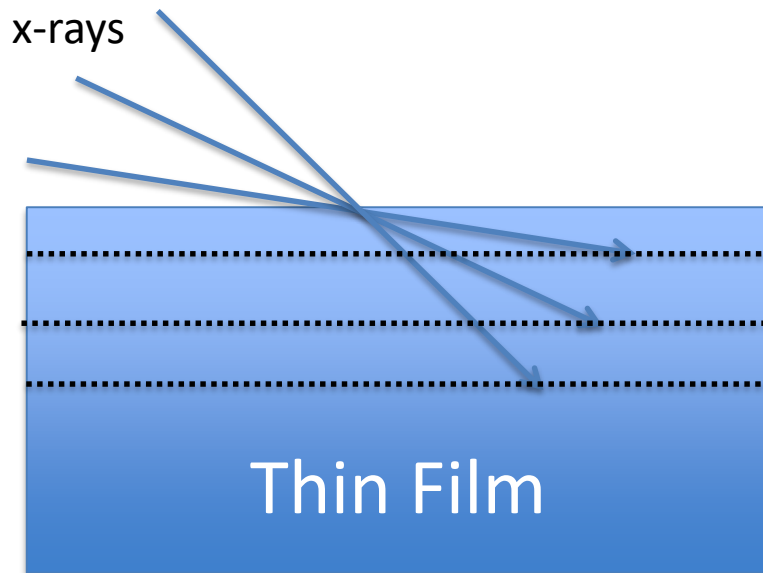


<https://www.sciencedirect.com/science/article/pii/S0022311517313946>



# Grazing incidence diffraction

## Depth sensitivity

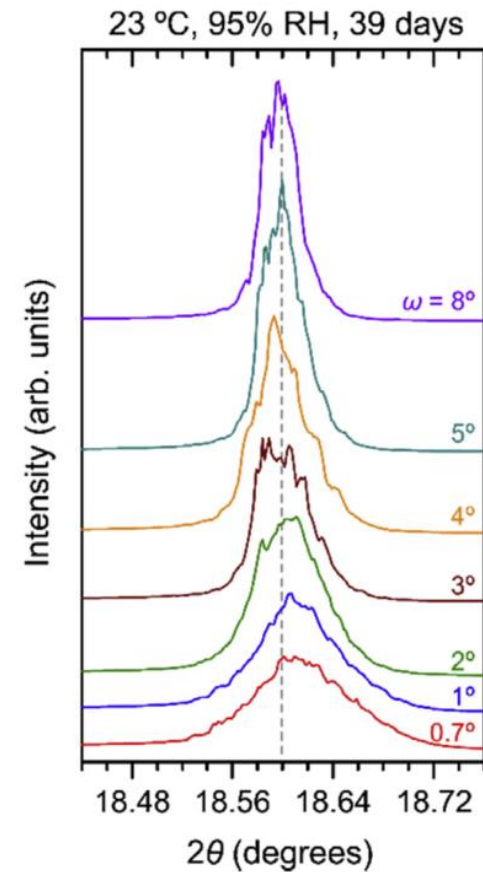
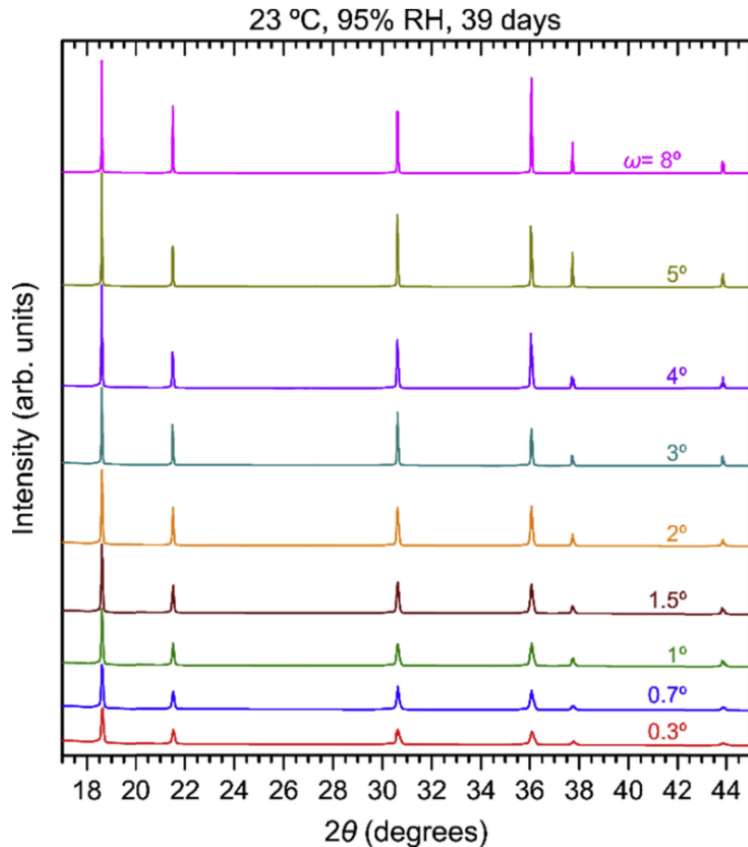


Journal of Nuclear Materials **502**: 68-75, 2018.





# Grazing incidence diffraction

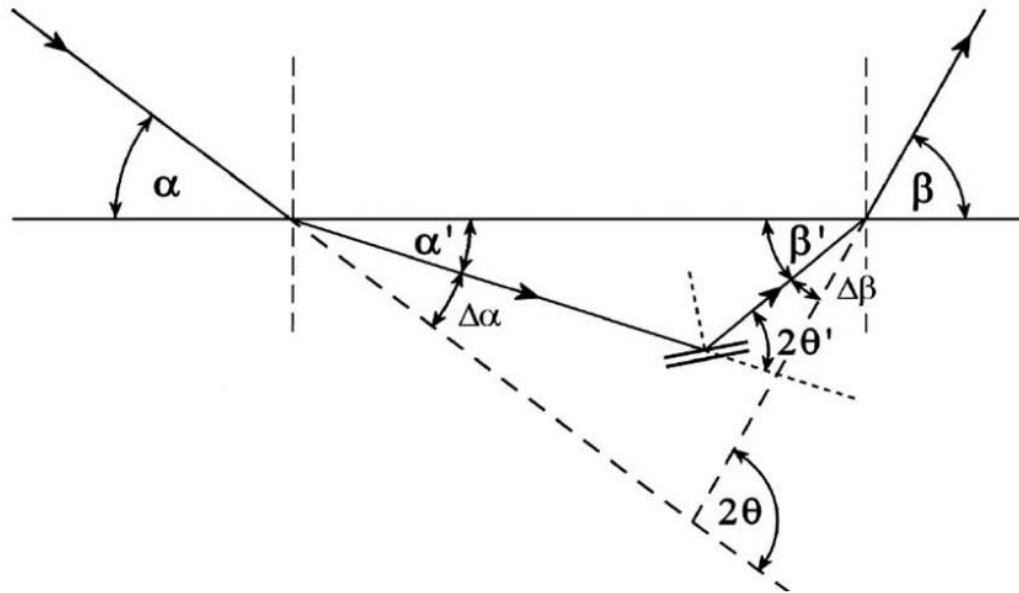


Journal of Nuclear Materials 502: 68-75, 2018.



# Grazing incidence diffraction

## Refraction correction



$$\Delta 2\theta = \delta [\cot \alpha + \cot(2\theta - \alpha) + 2 \tan \theta]$$

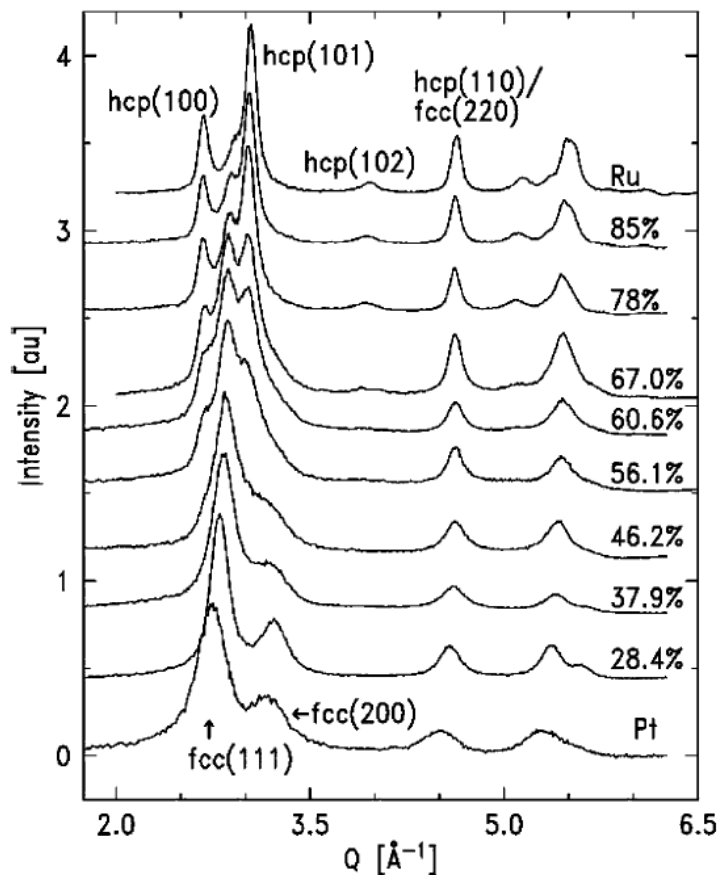
Powder Diffraction **24**(S1): S11-S15, 2012



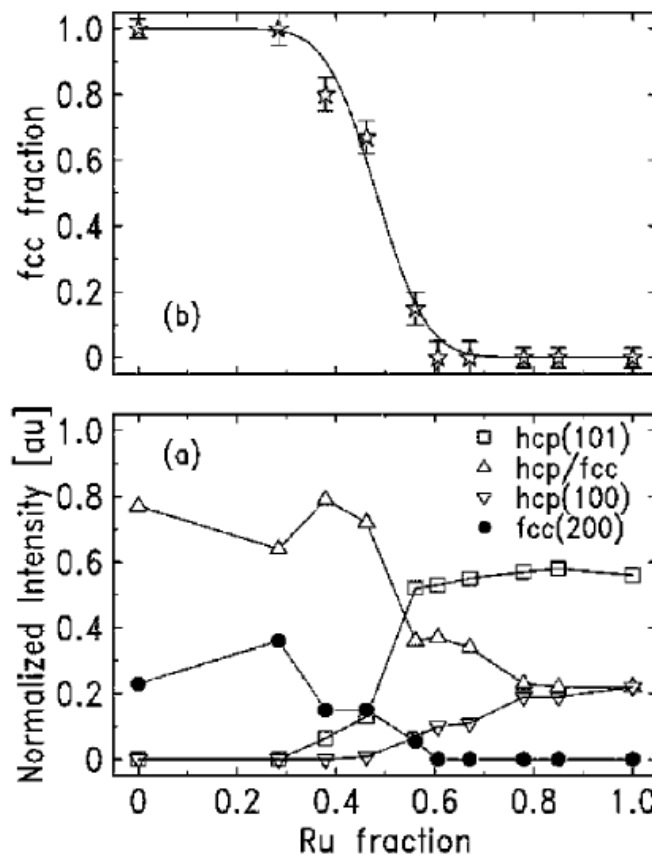
# Grazing incidence diffraction

## Structure and electrocatalysis of sputtered RuPt thin-film electrodes 130 Å thick

Grazing incidence x-ray diffraction



Phase diagram determination



# Grazing incidence diffraction

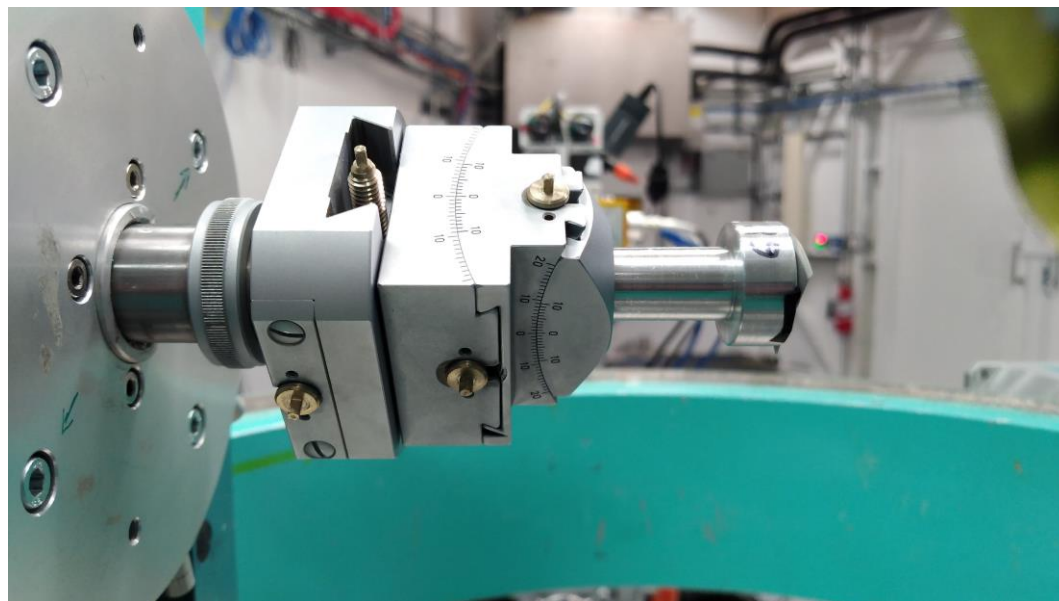
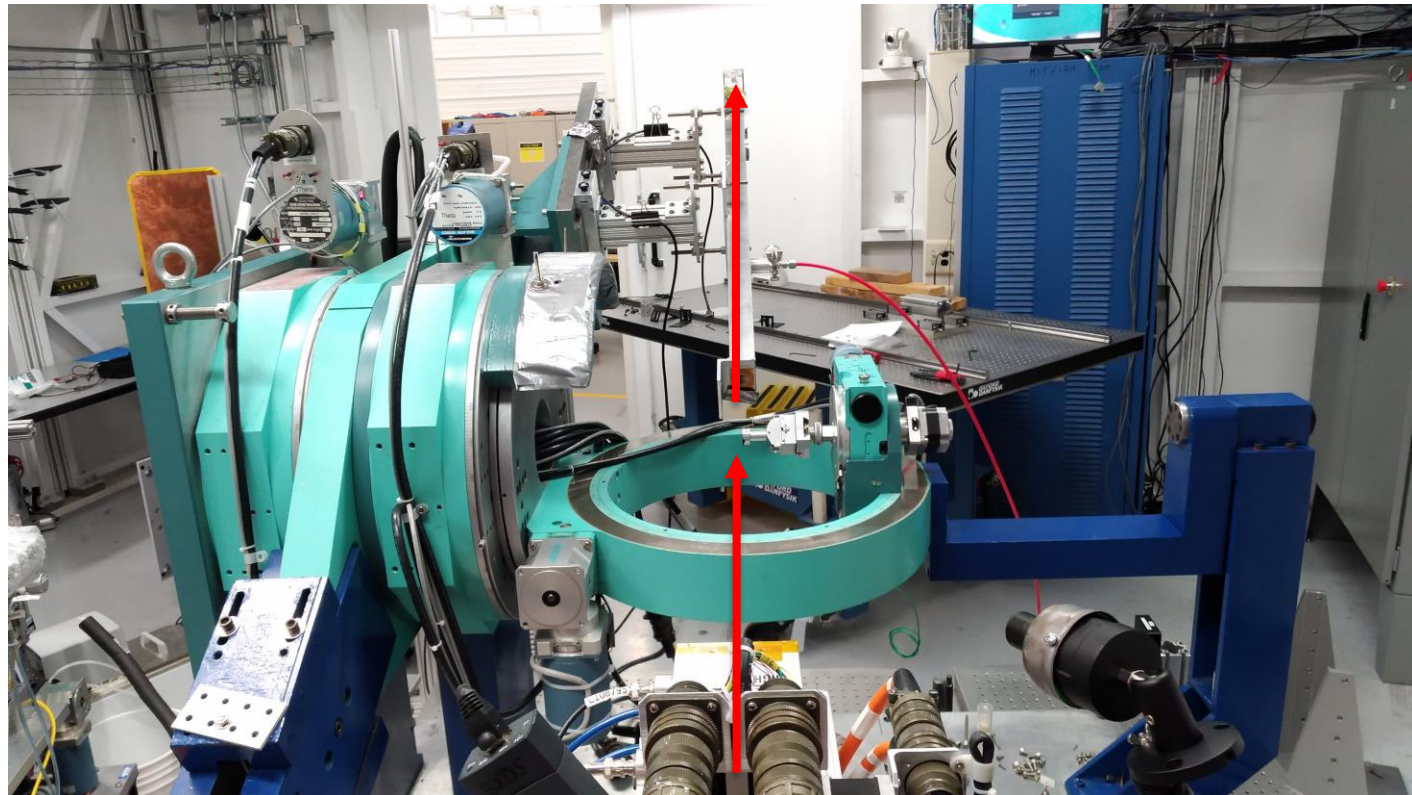
applied to

Single crystal films

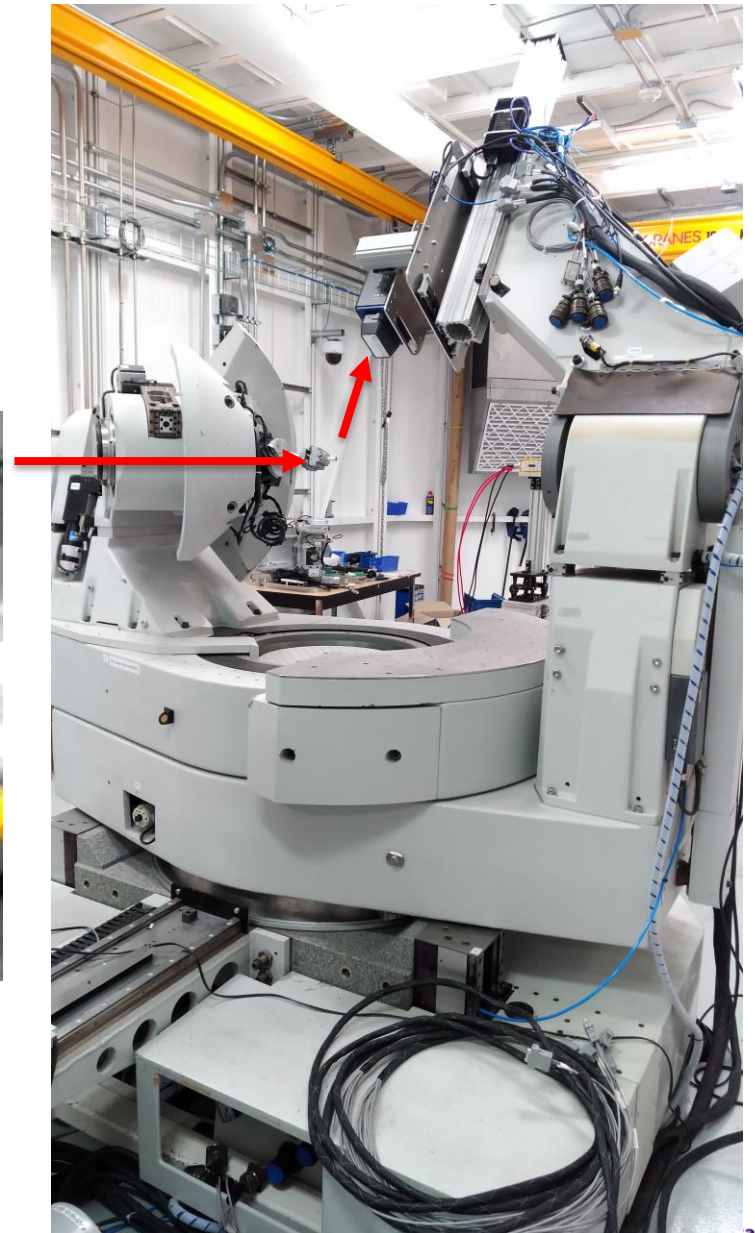
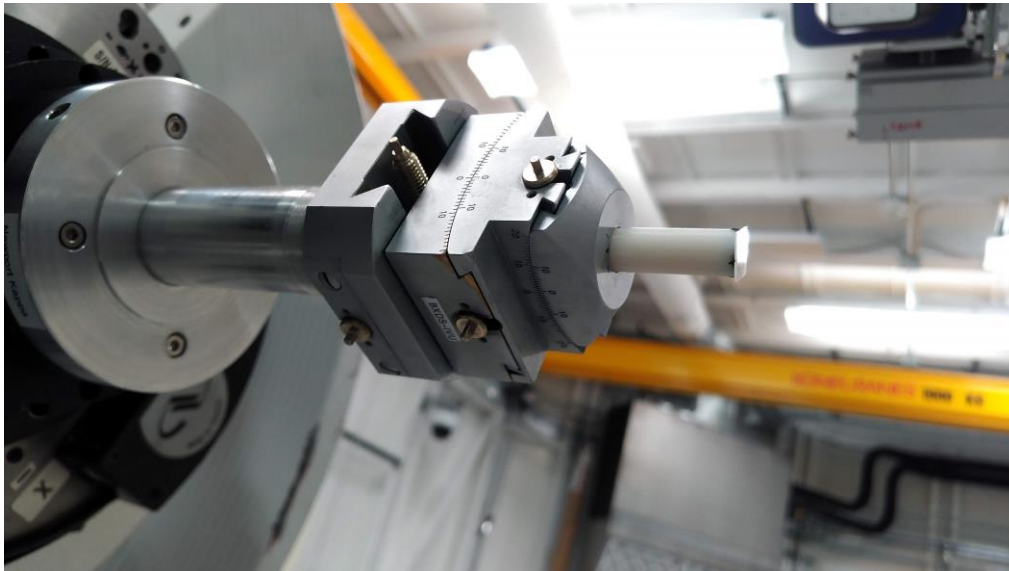




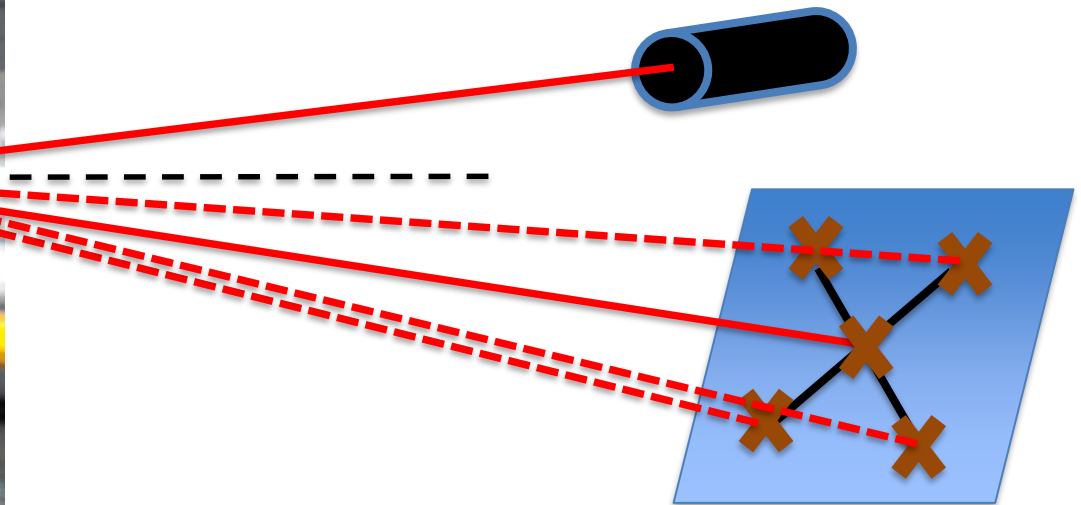
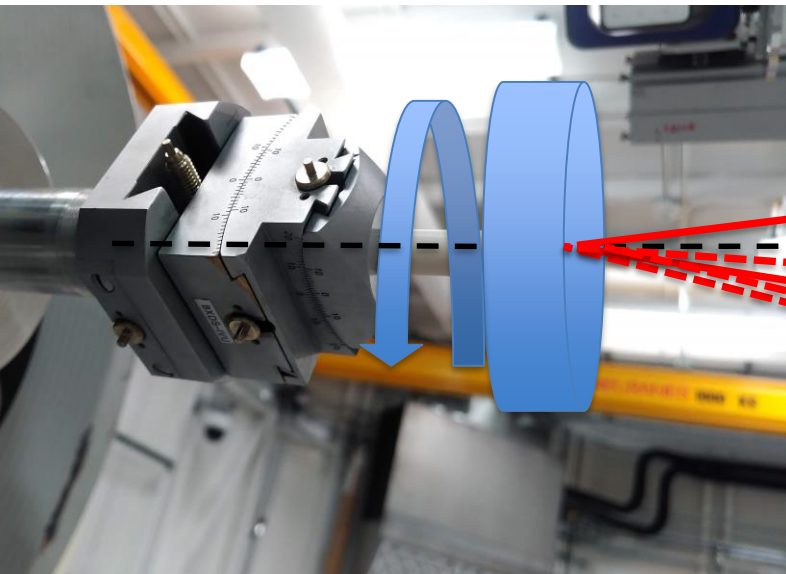
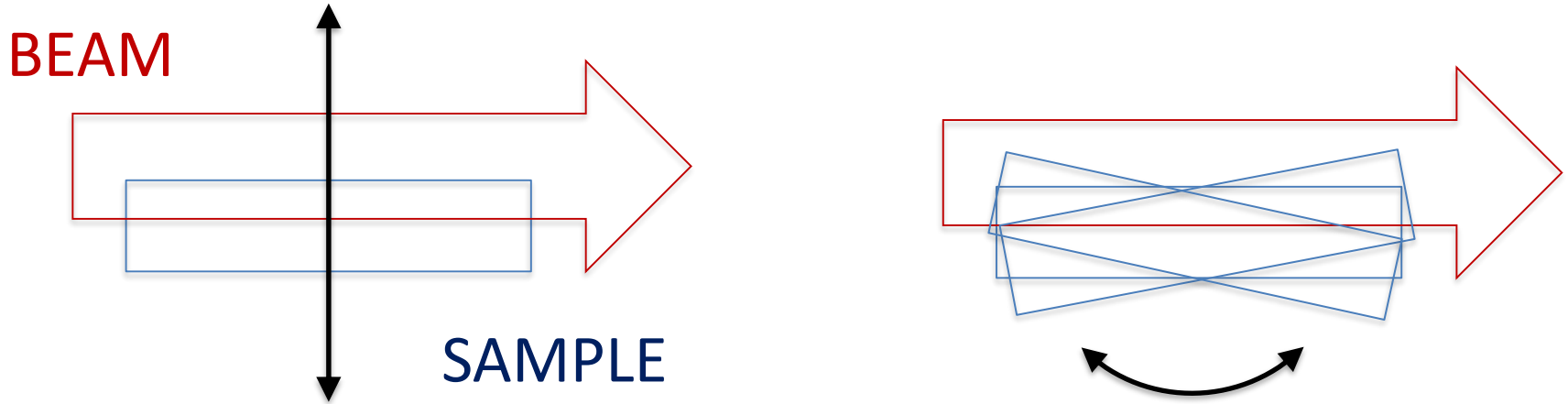
# GID setup



# GID setup

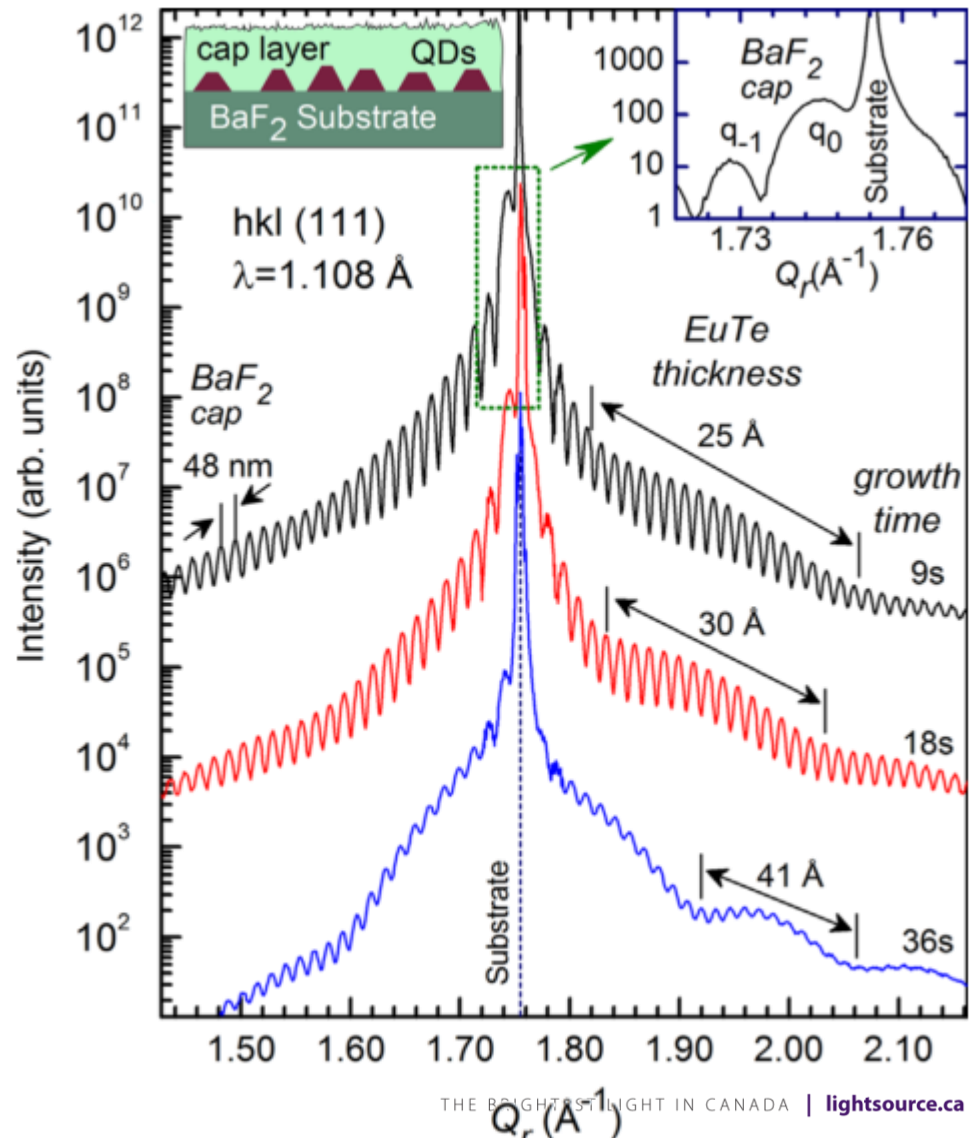
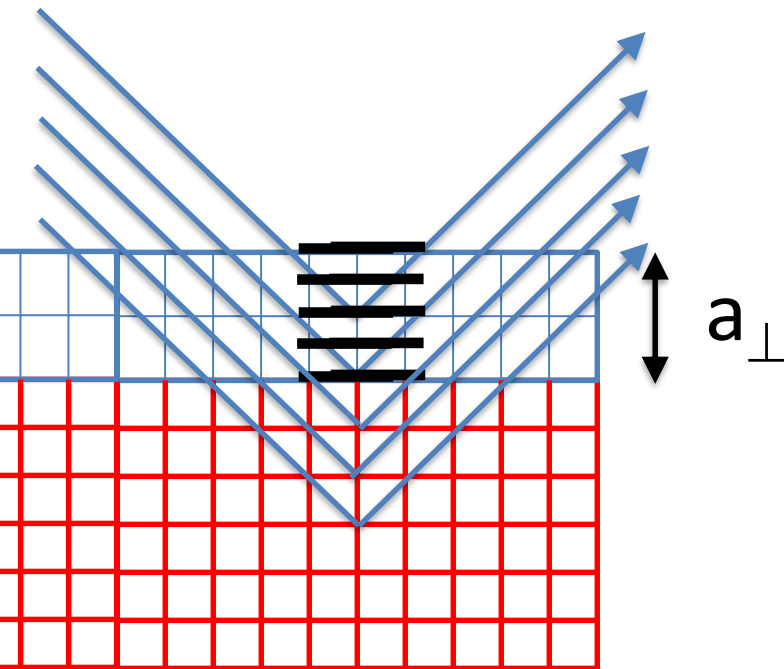


# Sample alignment

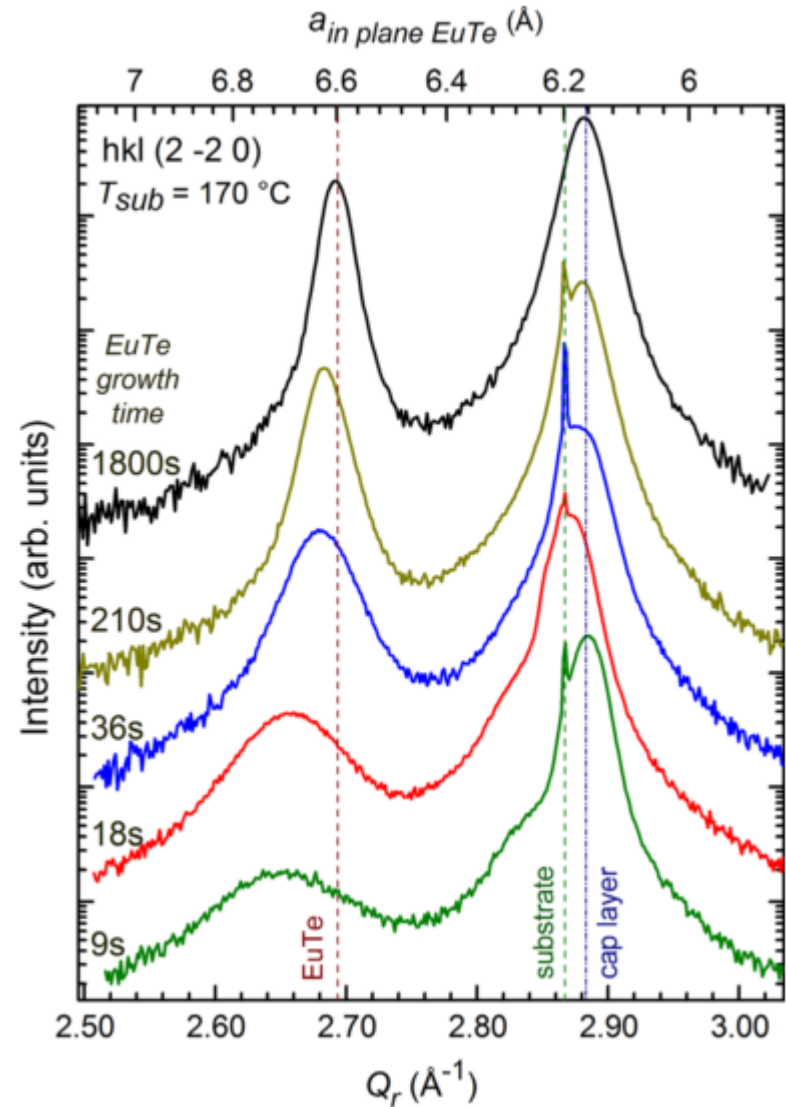
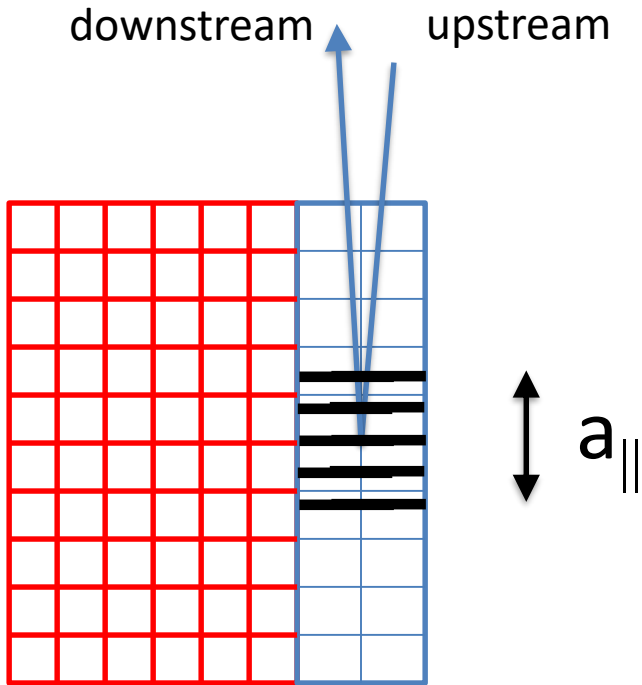




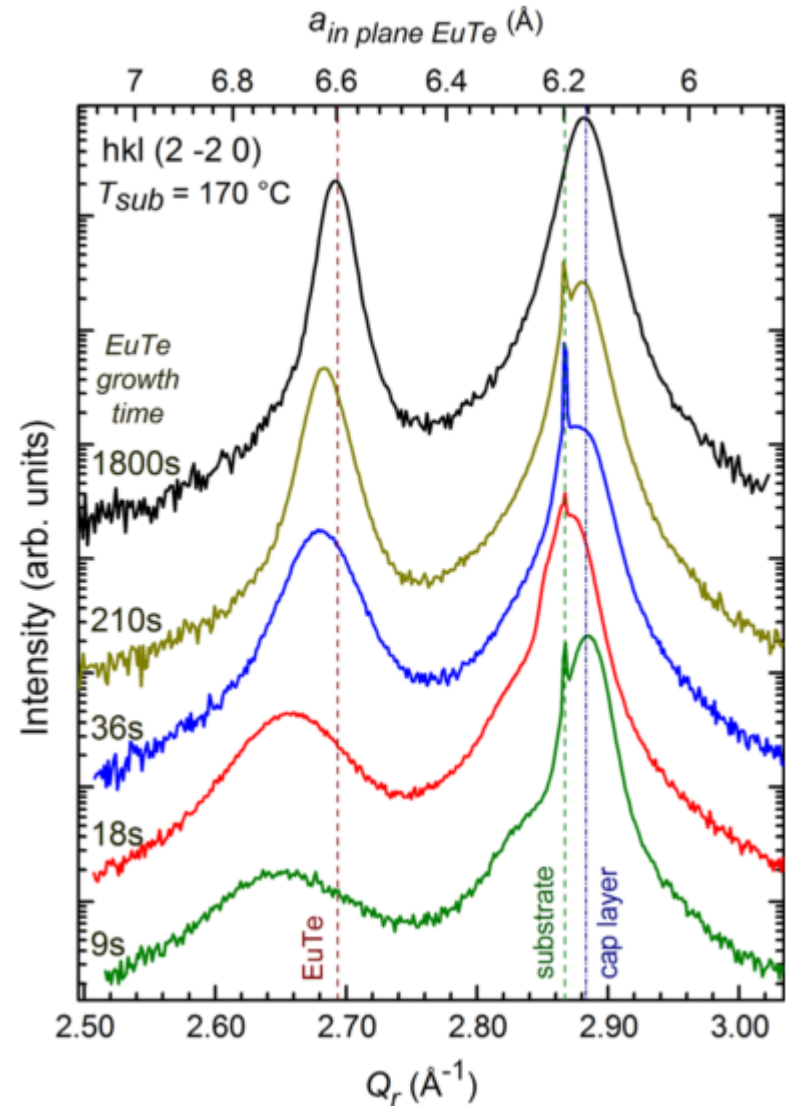
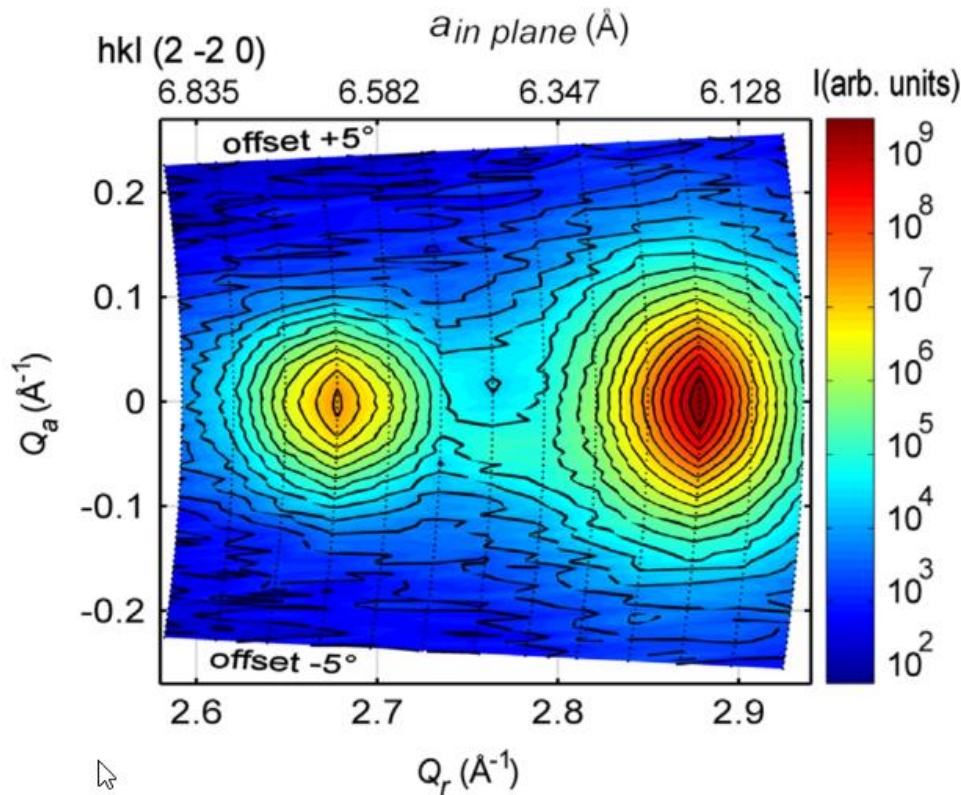
# Not-Grazing incidence diffraction



# Grazing incidence diffraction



# Grazing incidence diffraction





# Grazing incidence ~~diffraction~~

## Small angle x-ray reflectivity

Single crystal films

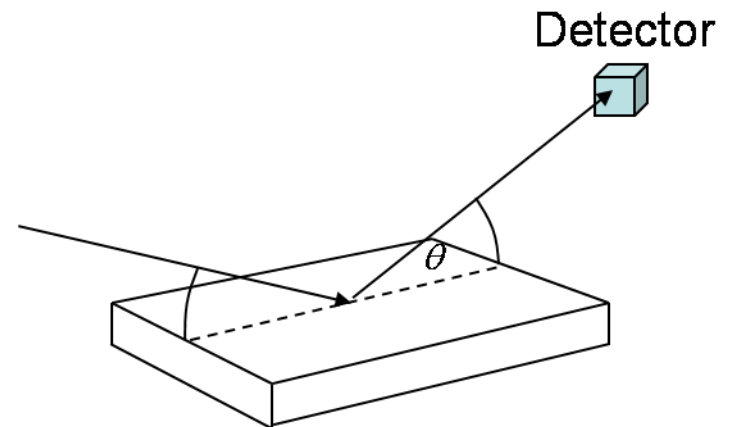
Polycrystalline films

Amorphous films



# Small angle X-Ray reflectivity

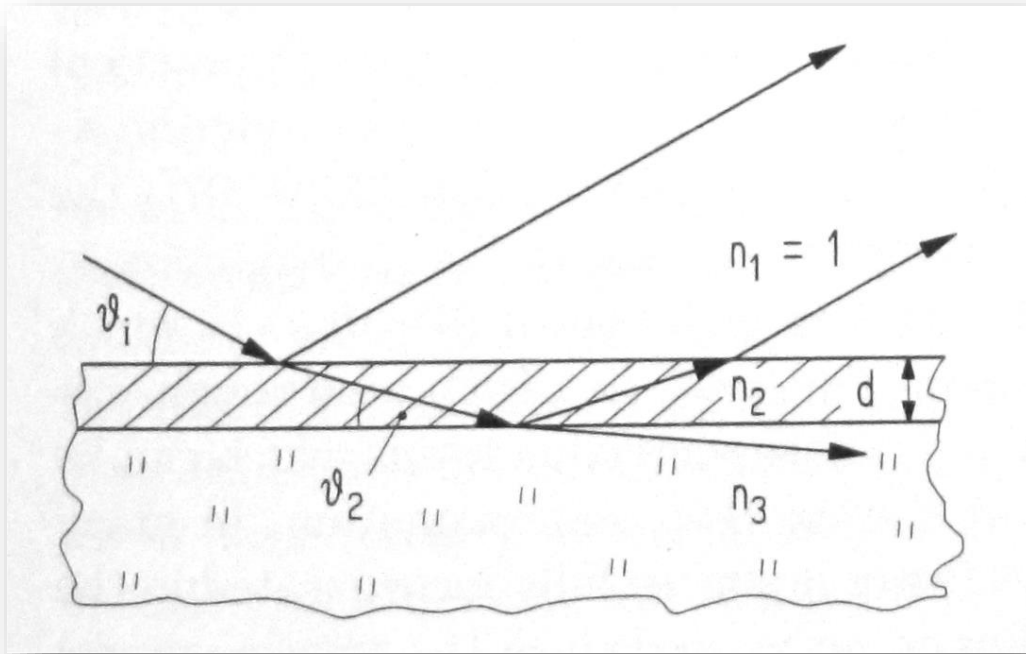
- Reflectivity yields information about the
  - Thicknesses
  - Density / porosity
  - Roughness of the interfaces
- Other names:
  - X-ray specular reflectivity
  - X-ray reflectometry
  - XRR



*No diffraction!*



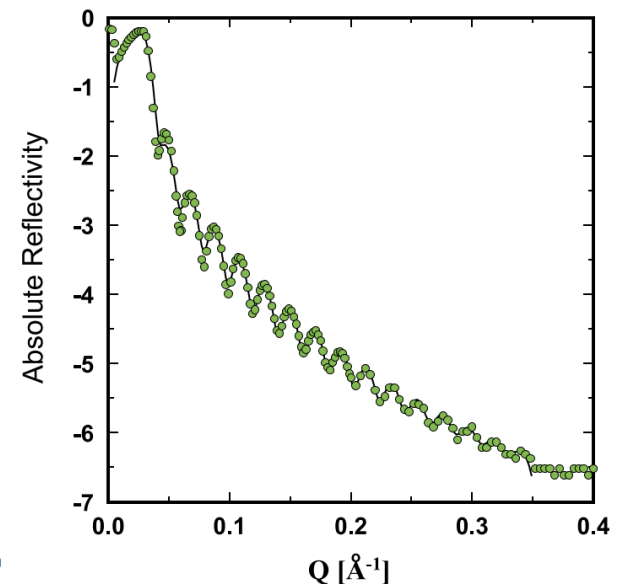
# Small angle X-Ray reflectivity



*Snell's law*

$$n_1 \cos \vartheta_1 = n_2 \cos \vartheta_2$$

$$n = 1 - \delta + i\beta$$

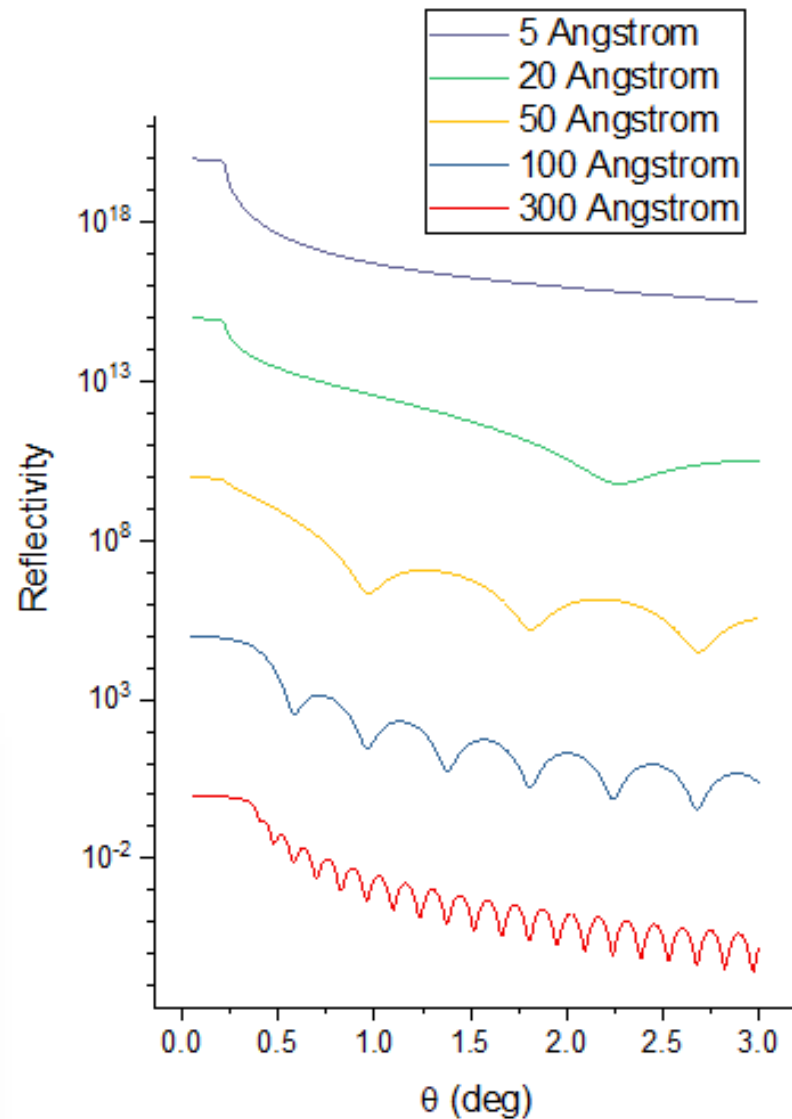
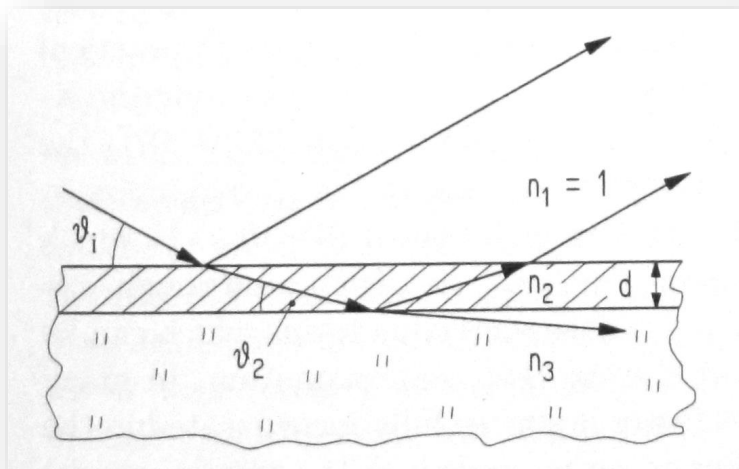


# Small angle X-Ray reflectivity

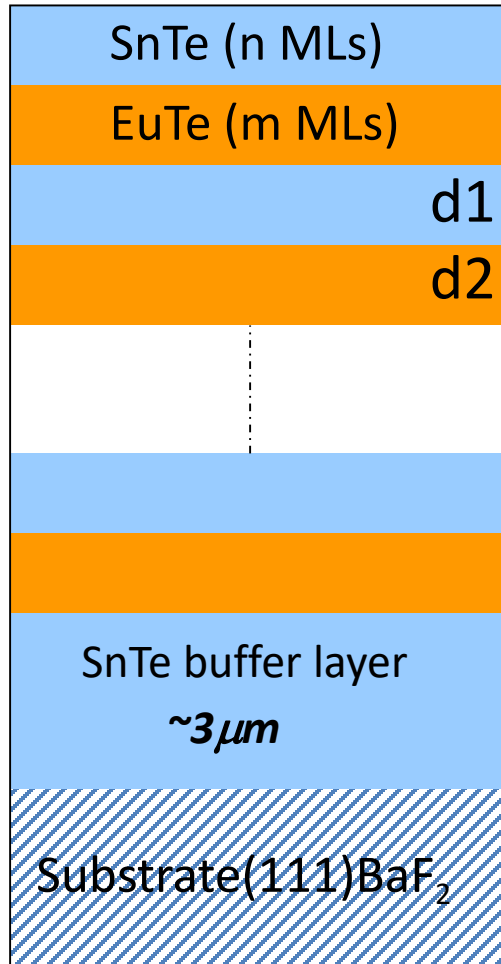
Reflectivity of a chromium film on top of silicon substrate, Cr/Si, for different thicknesses between 5 and 300 Å.

Kiessig fringes

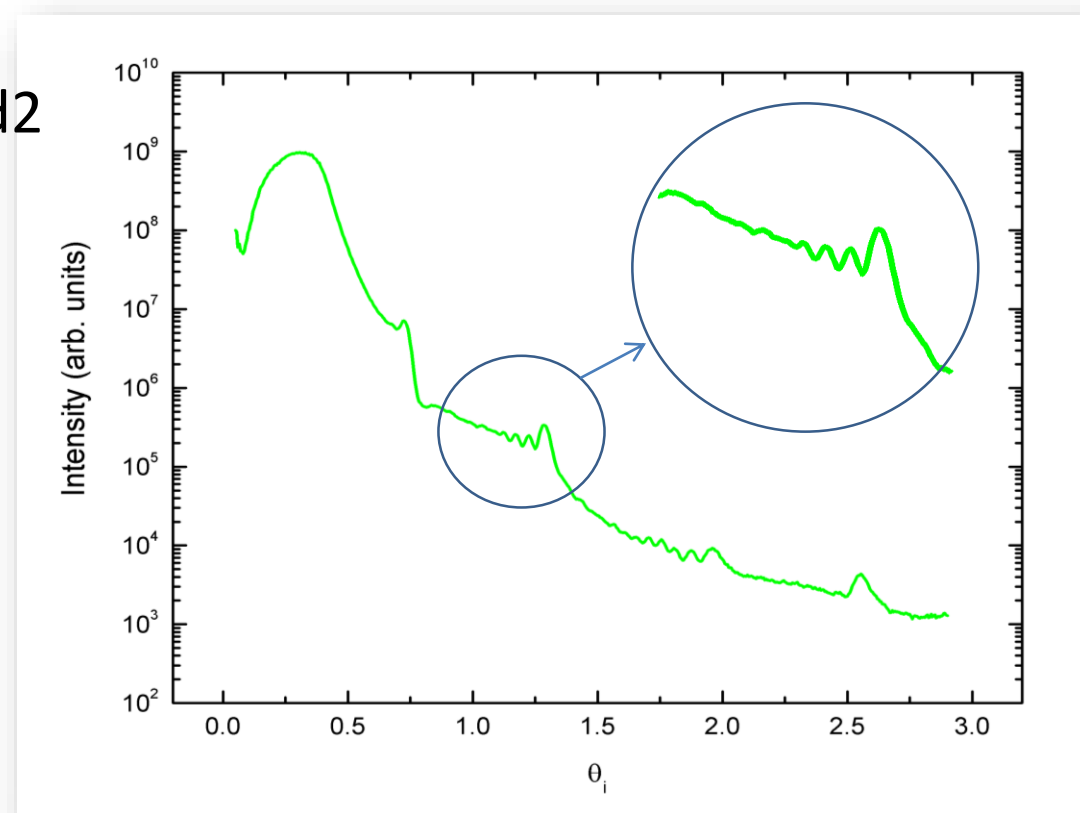
$$d = \frac{\lambda}{2\Delta\theta_r}$$



# Small angle X-Ray reflectivity



$$D=d1+d2$$



$$d = \frac{\lambda}{2\Delta\vartheta_i}$$

Kiessig fringes spacing:

0.61 deg ~ 83 Å (SL period)

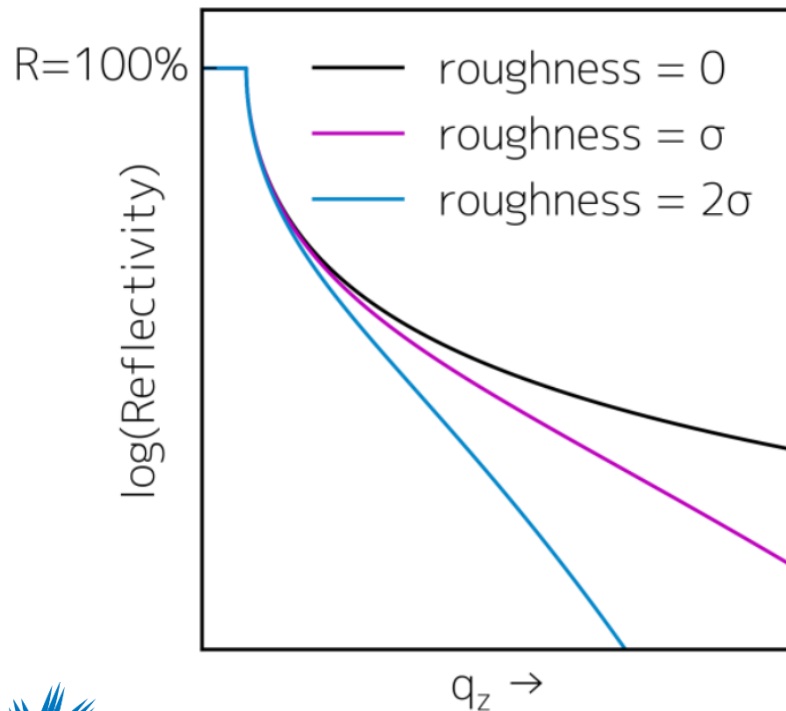
0.05 deg ~ 994.9 Å (Stack thickness)



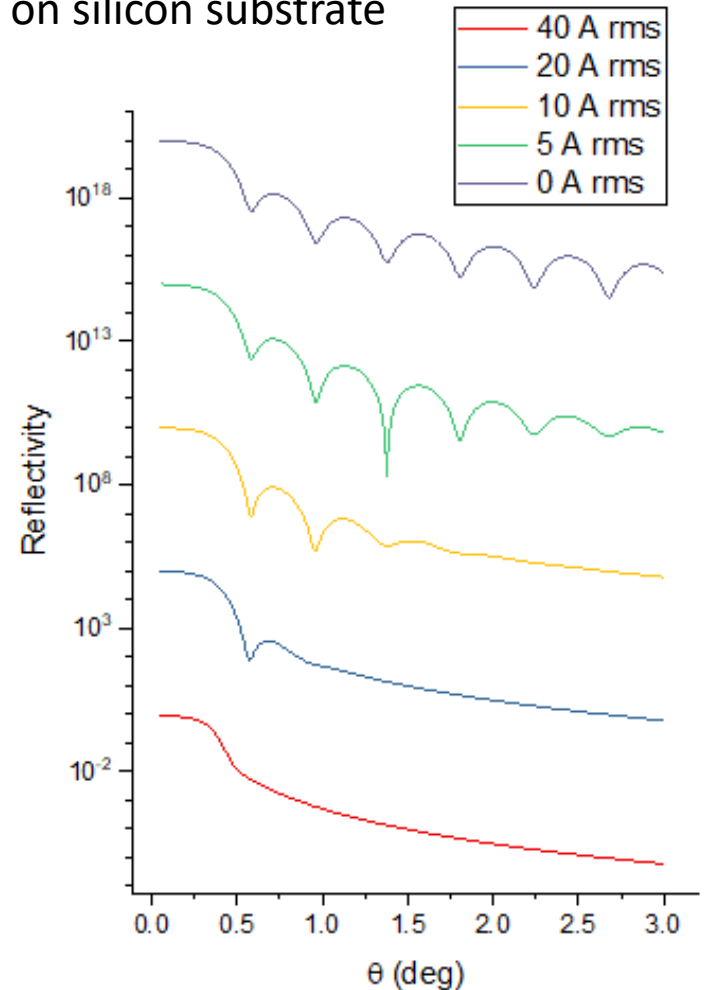
# Small angle X-Ray reflectivity

## Surface roughness

$$R_{rough} = R \cdot e^{-\frac{q_z^2 \sigma^2}{2}}$$



100 Angstrom chromium layer  
on silicon substrate





# Small angle X-Ray reflectivity

Footprint correction

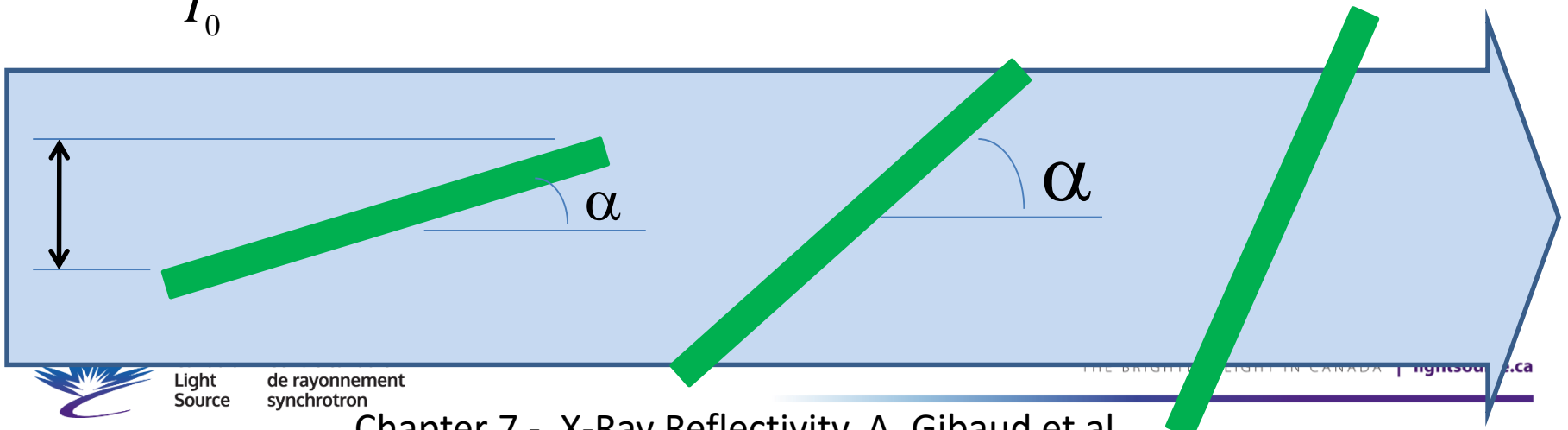
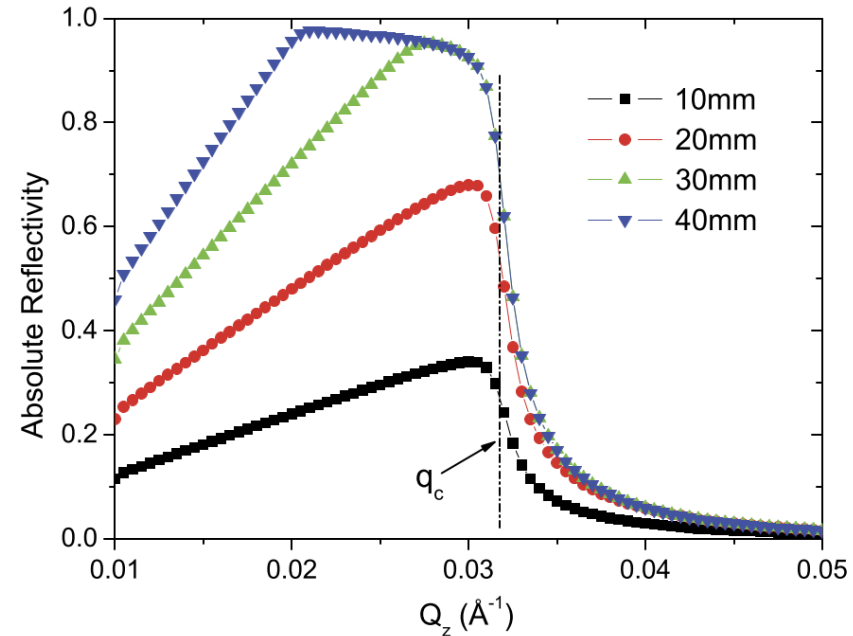
Critical angle

$$\theta_c \sim \lambda \sqrt{\rho}$$

Beam footprint length

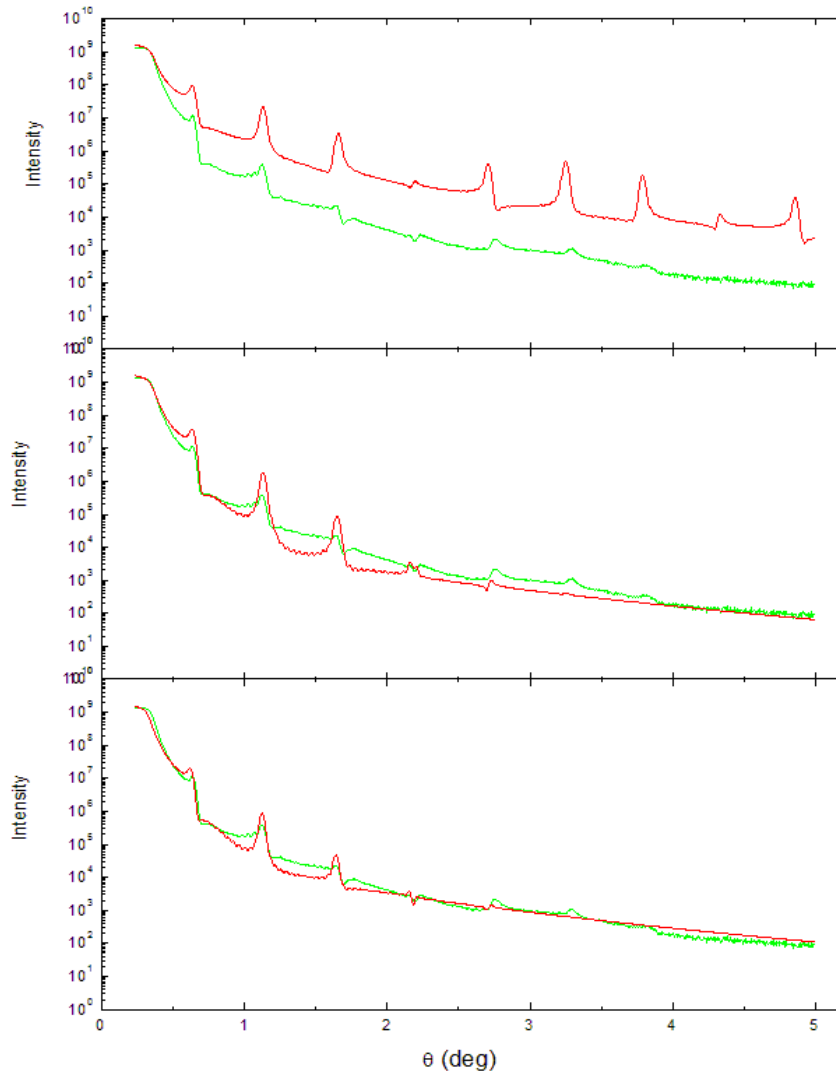
$$F = \frac{t}{\sin(\alpha)}$$

$$R = \frac{I}{I_0}$$



# Small angle X-Ray reflectivity

Fits to the measurement



← Smooth interfaces

← Rough interfaces

← Lower densities  
(porous sample?)

Oxide layer cap!  
THE BRIGHTEST LIGHT IN CANADA | [lightsource.ca](http://lightsource.ca)

# Programs for simulating and fitting reflectivity

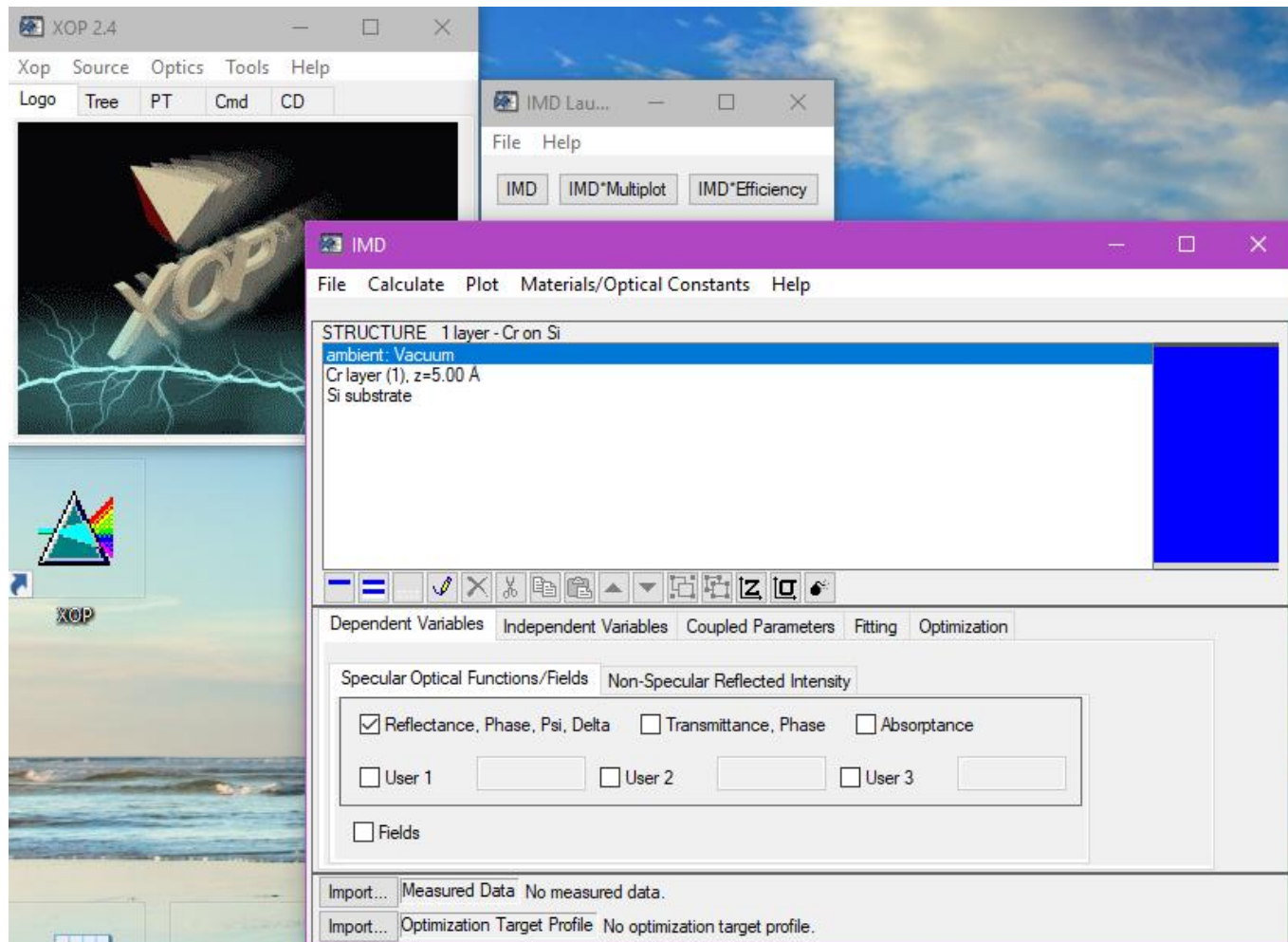
- Parratt 32
- RFit2000
- WinGixa (Panalytical)
- **XOP / IMD**
- GSAS II !

For more x-ray related softwares consult website:

<http://gisaxs.com/index.php/Software#Crystallography>



# IMD/XOP to simulate x-ray reflectivity



<https://www.aps.anl.gov/Science/Scientific-Software/XOP>



Canadian  
Light  
Source Centre canadien  
de rayonnement  
synchrotron

<http://www.rxollc.com/idl/IMD.pdf>

THE BRIGHTEST LIGHT IN CANADA | [lightsource.ca](http://lightsource.ca)

# IMD/XOP to simulate x-ray reflectivity

The screenshot displays the XOP 2.4 software interface. The main window, titled "IMD", shows a structure definition and a list of dependent variables. The structure is defined as "STRUCTURE 1 layer - Cr on Si" with an ambient of "Vacuum", a "Cr layer (1), z=5.00 Å", and a "Si substrate". The dependent variables include "Grazing Incidence Angle, Theta [1000 values: 0.050-3.000 deg]" and "Wavelength, Lambda [1.540 Å]". The interface also features a menu bar, a toolbar, and a status bar at the bottom.

Xop Source Optics Tools Help  
Logo Tree PT Cmd CD

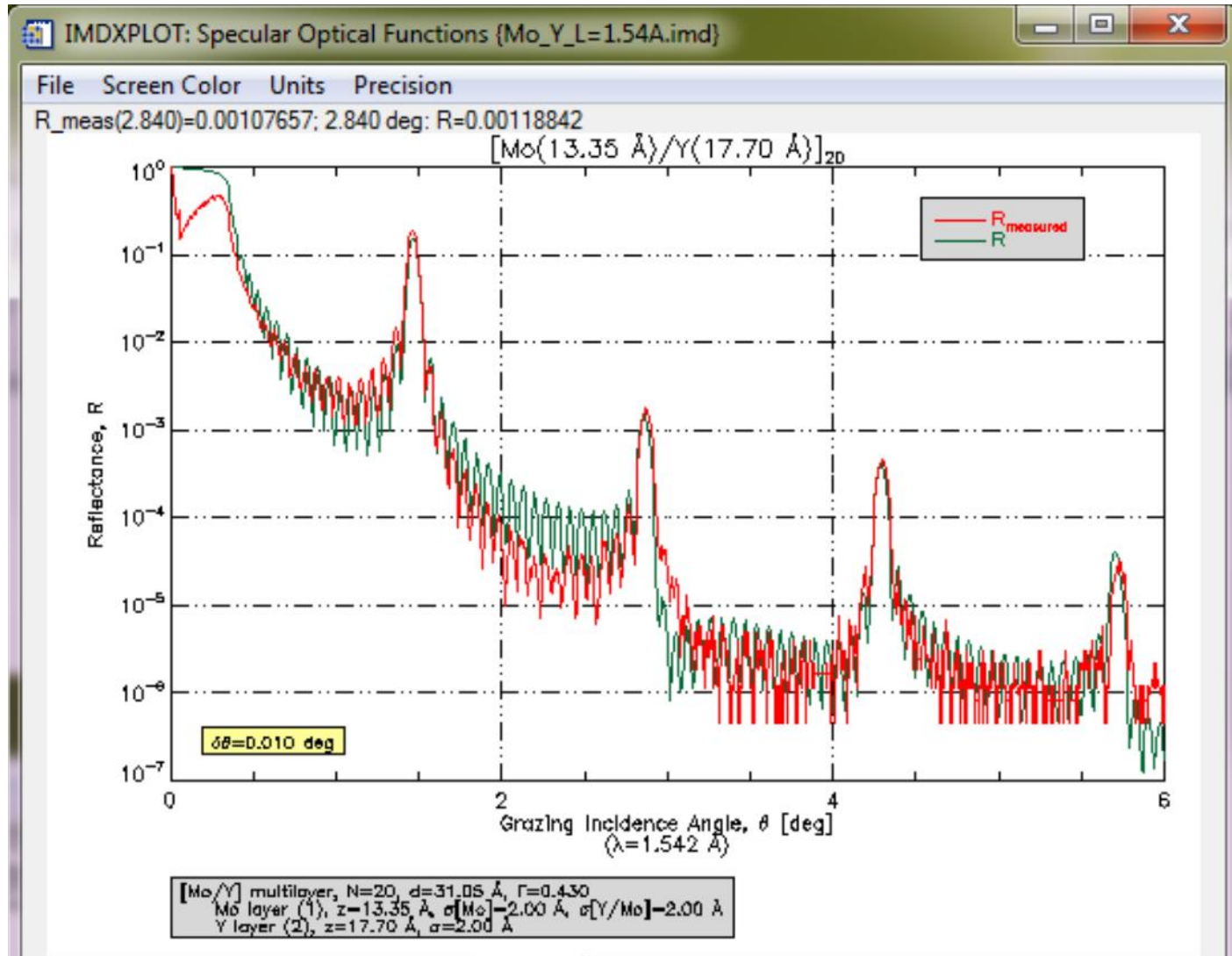
IMD Lau...  
File Help  
IMD IMD\*Multiplot IMD\*Efficiency

IMD  
File Calculate Plot Materials/Optical Constants Help  
Select independent variables to edit or remove.  
STRUCTURE 1 layer - Cr on Si  
ambient: Vacuum  
Cr layer (1), z=5.00 Å  
Si substrate

Dependent Variables Independent Variables Coupled Parameters Fitting Optimization  
Grazing Incidence Angle, Theta [1000 values: 0.050-3.000 deg]  
Wavelength, Lambda [1.540 Å]

Import... Measured Data No measured data.  
Import... Optimization Target Profile No optimization target profile.

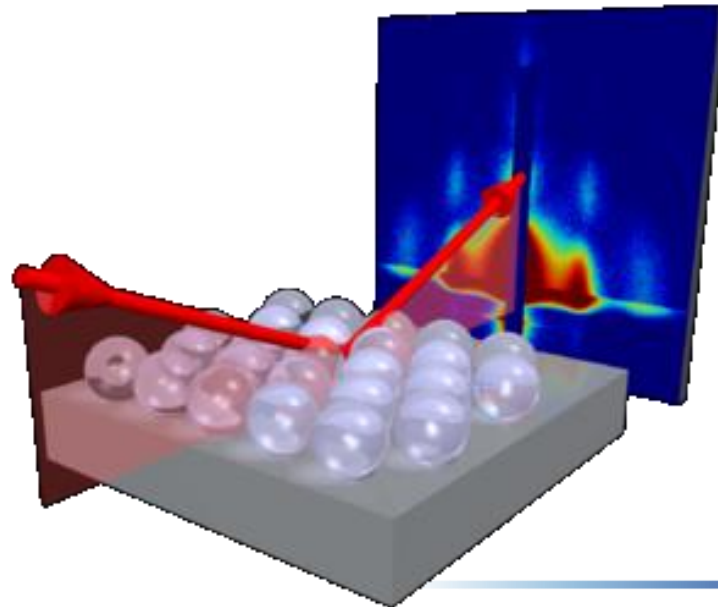
# IMD/XOP to simulate x-ray reflectivity



# Grazing incidence

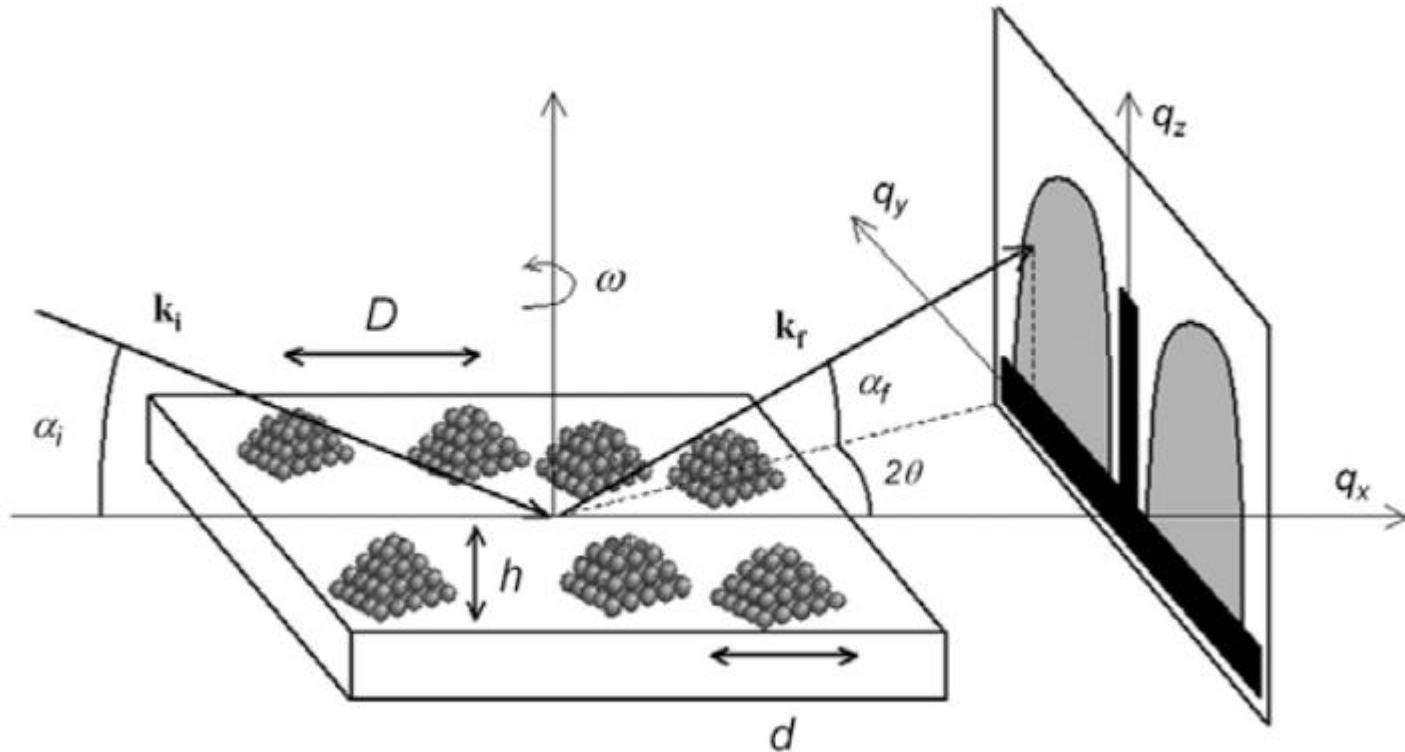
## Small angle X-ray scattering

### GISAXS





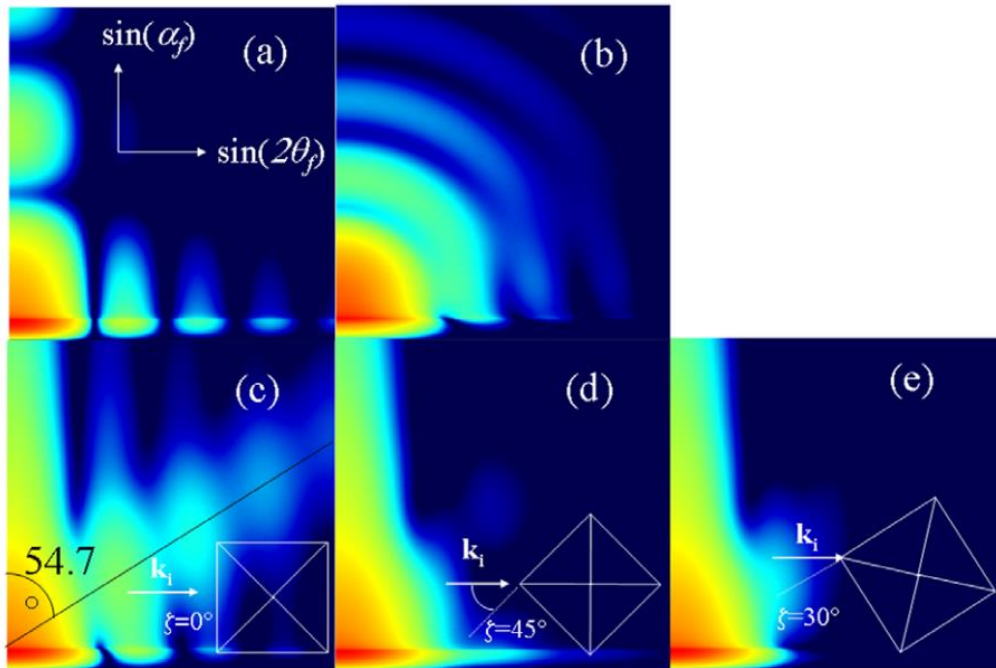
# GISAXS



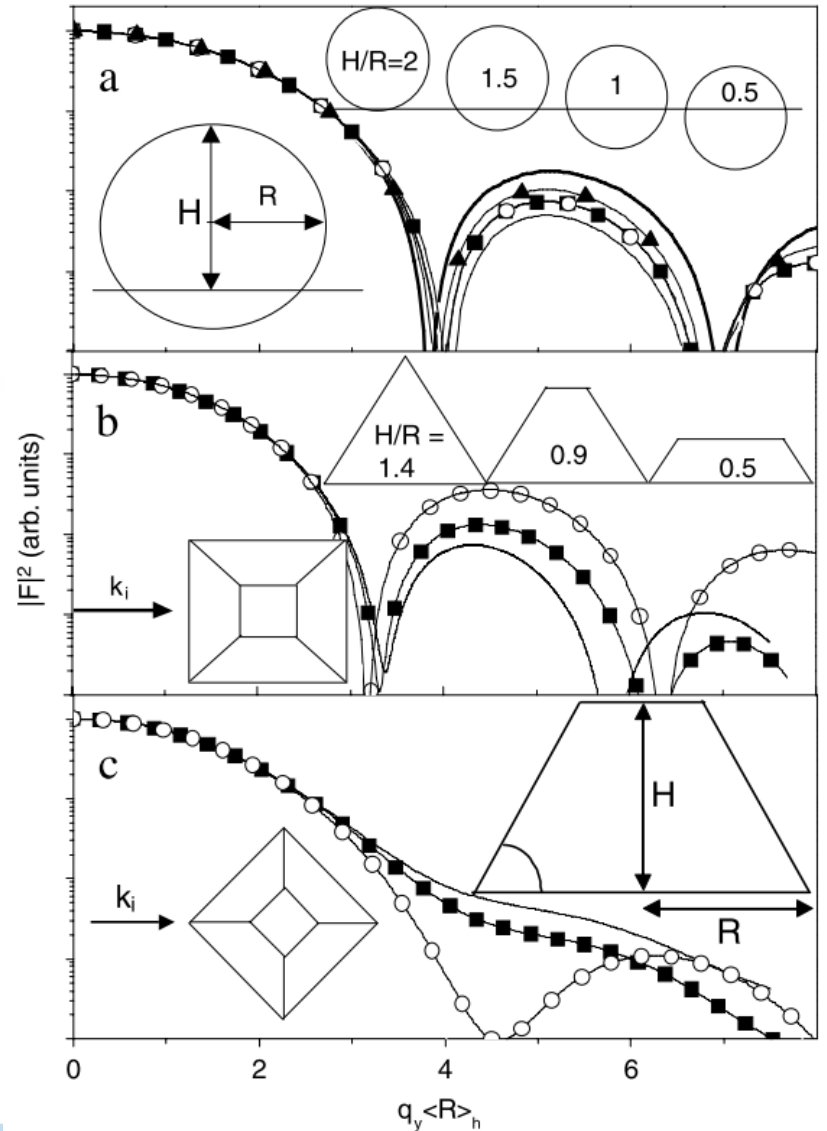
Surface Science Reports **64**(8): 255-380.



# GISAXS



$q_y$



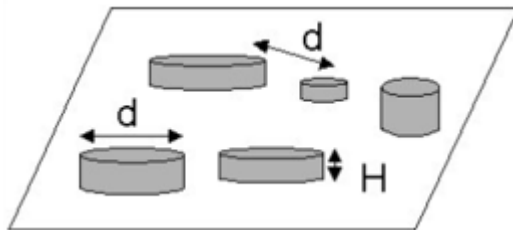
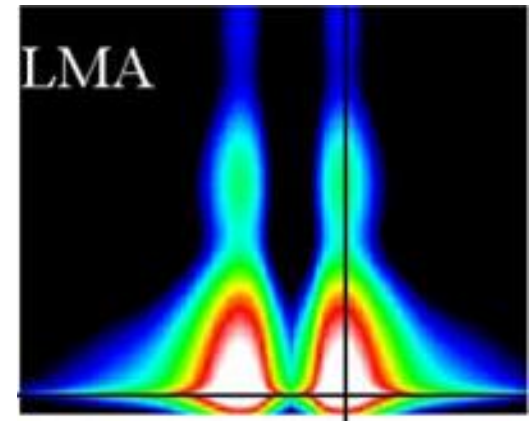
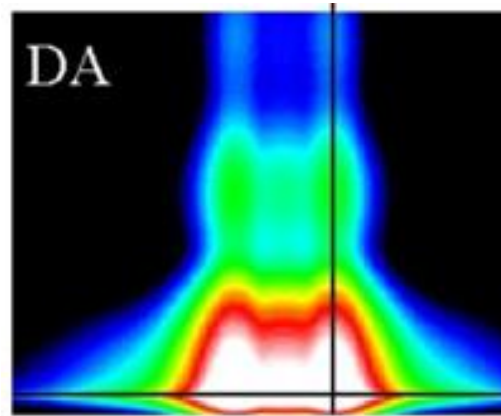
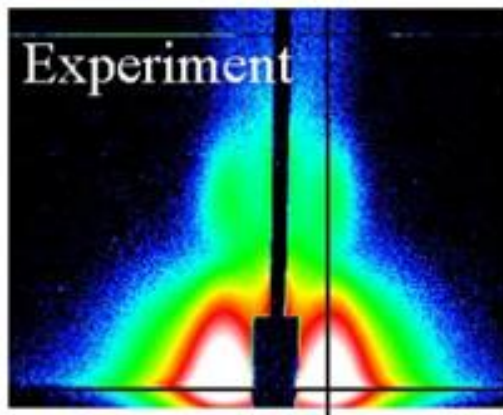
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# Modelling software

- R. Lazzari, IsGISAXS: A program for grazing-incidence small-angle X-ray scattering analysis of supported islands, J. Appl. Crystallogr. 35 (2002) 406–421.
- <http://www.insp.jussieu.fr/oxydes/IsGISAXS/isgisaxs.htm>
- Jiang, Z. (2015). "GIXSGUI: a MATLAB toolbox for grazing-incidence X-ray scattering data visualization and reduction, and indexing of buried three-dimensional periodic nanostructured films." Journal of Applied Crystallography **48**(3): 917-926.
- <https://www.aps.anl.gov/Science/Scientific-Software/GIXSGUI>
- FitGISAXS, BornAgain, HipGISAXS, NANOCELL, SimDiffraction,...



# IsGISAXS

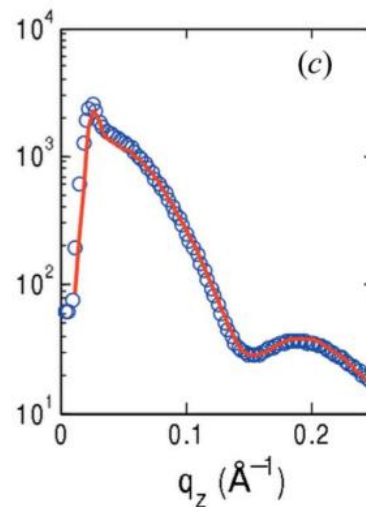
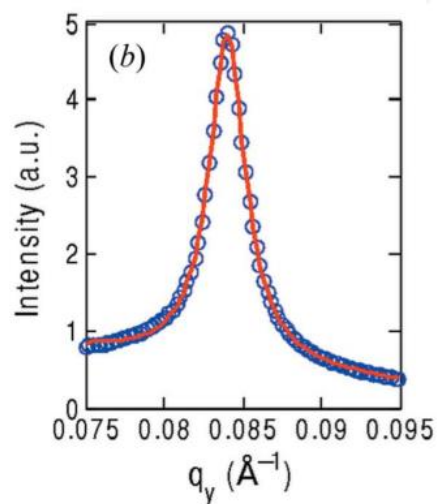
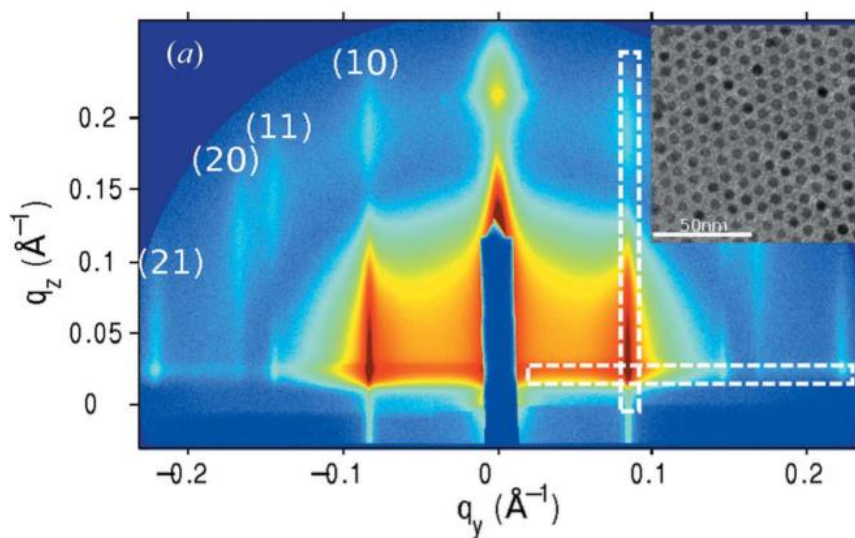


## PARAMETERS :

cylinder  
 $D = 20.7 \text{ nm}$   
 $d = 10.2 \text{ nm}$   
 $H = 6.6 \text{ nm}$   
 $\sigma_R = 1.3$   
 $\sigma_H = 1.1$



# GISAXS





# In Situ GISAXS Study of Gold Film Growth on Conducting Polymer Films

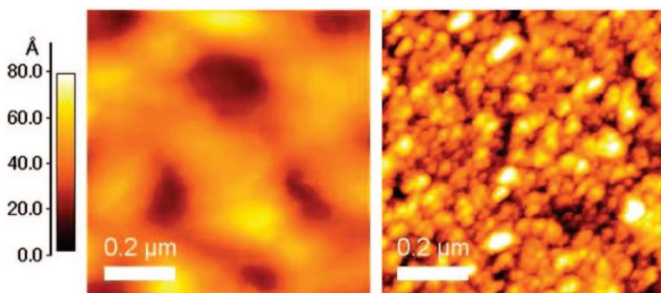
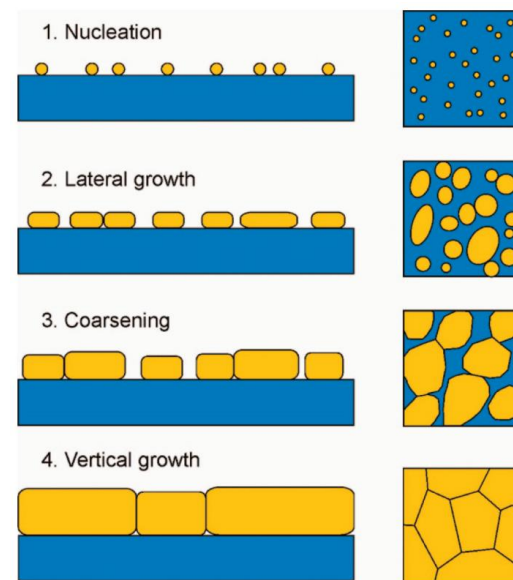
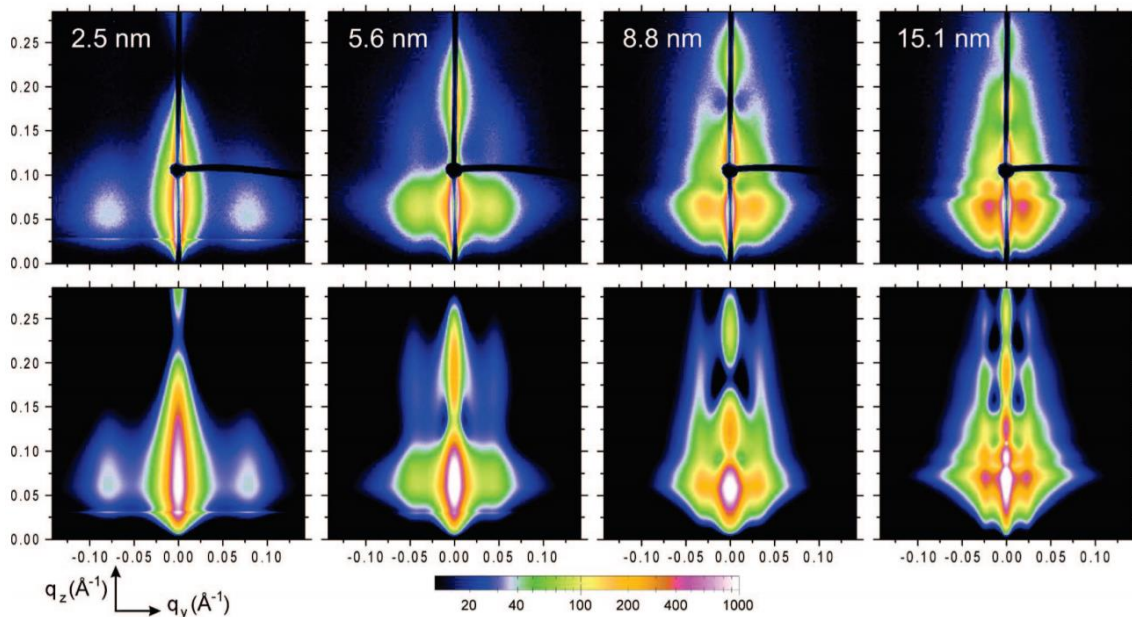


Table 1. Morphological Parameters Extracted from Simulation of the Data by Use of a Model Consisting of Parallelepiped and Spheroid Particle Geometries To Describe the Cluster Shape<sup>a</sup>

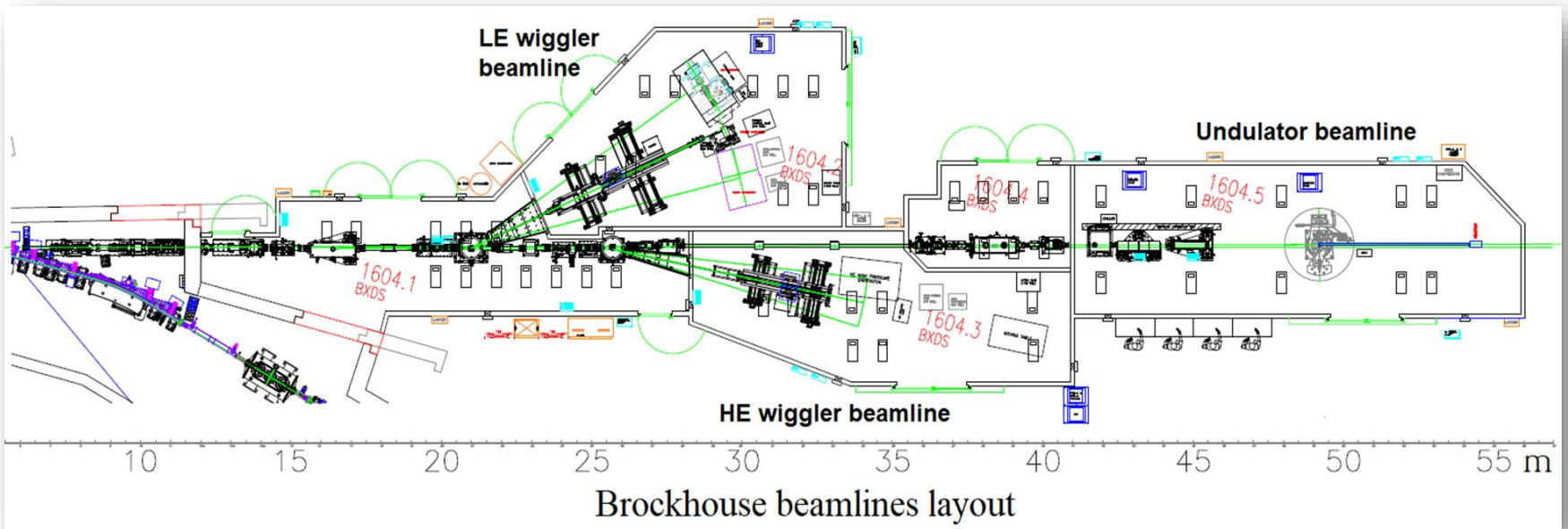
$t$ (min)	$d_0$ (nm)	$d$ (nm)	$r_p$ (nm)	$\sigma_p$ (nm)	$h_p$ (nm)	$r_s$ (nm)	$\sigma_s$ (nm)	$h_s$ (nm)	$D$ (nm)	$\omega$ (nm)
9	3.9	2.5	4.8	20.0	3.6	4.8	11.0	4.3	11.8	3.8
19	8.2	5.6	9.1	22.5	6.1	9.1	5.3	6.8	19.0	7.2
29	12.5	8.8	13.5	17.6	8.8	13.5	14.9	9.9	27.0	10.2
49	21.1	15.1	20.0	36.0	15.2	20.0	18.0	16.4	40.0	15.2



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# Thin film characterization at the Brockhouse sector



## Beamlines energy range

Lower energy wiggler beamline: 7 – 22 keV

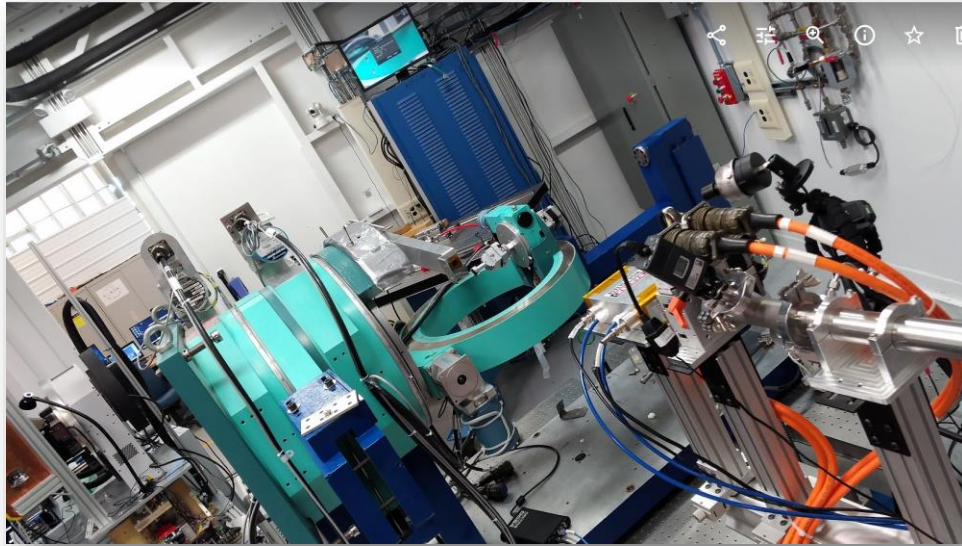
Undulator beamline: 5 – 24 keV

Higher Energy wiggler beamline: 20 – 95 keV



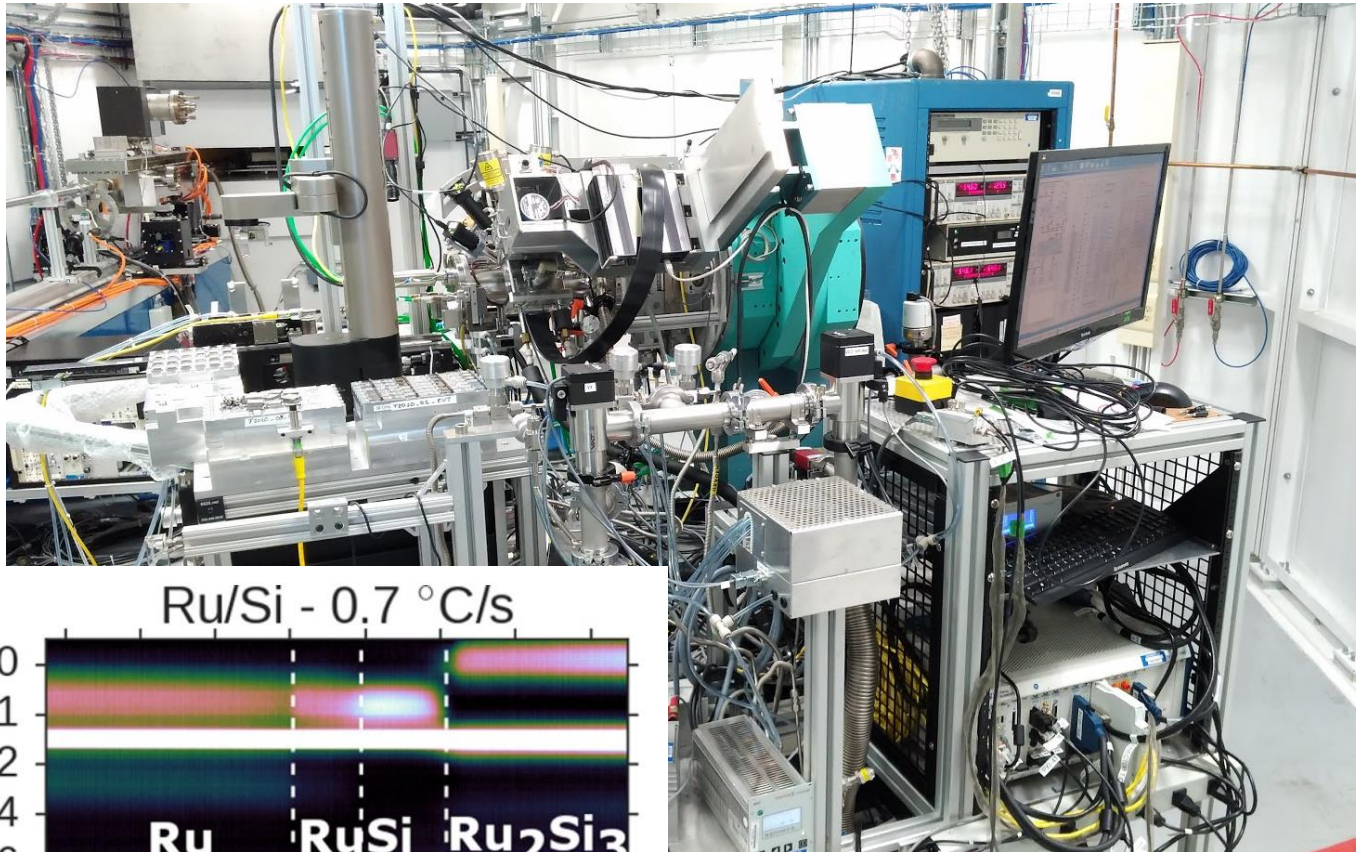


# Thin film characterization at the Brockhouse sector





# Thin film characterization at the Brockhouse sector



IBM in-situ station

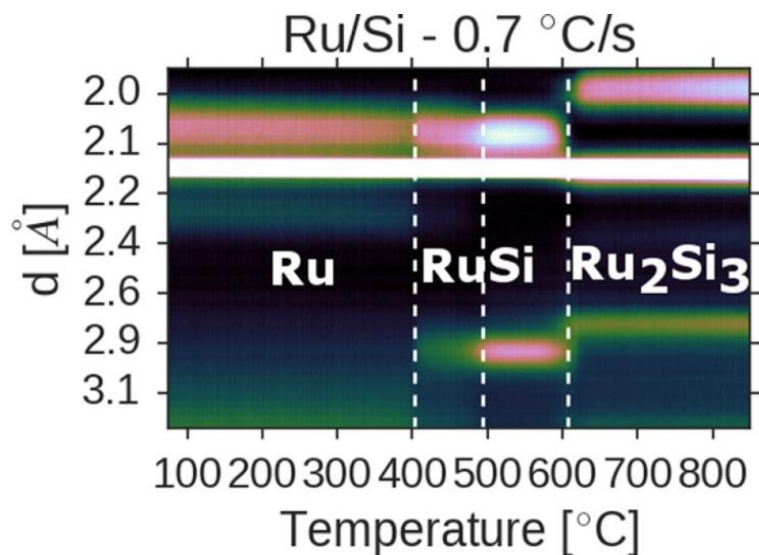
XRD

RTA up to 1000 °C

H<sub>2</sub> or N<sub>2</sub> ultrahigh purity atmosphere

Resistance probe

Roughness probe





# Brockhouse Diffraction Sector Beamlines

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User Guide ▾

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Welcome to the Brockhouse homepage. We provide a wide range of complementary diffraction and scattering techniques to fully characterize your materials.

High Resolution Powder Diffraction

Total Scattering for PDF

Single Crystal Diffraction

In-Situ Diffraction

High Pressure Crystallography

High energy diffraction for in-situ studies

Reciprocal Space Mapping

Small angle X-ray reflectivity

Grazing incidence diffraction (GID)

Grazing incidence small angle X-ray diffraction (GISAXS)

Anomalous diffraction and magnetic diffraction



# Conclusions

If you have a sample... → measure XRD!

If it is a very thin film... → try one of the techniques with grazing incidence geometry

They yield information about:

- ✓ Structure / texture / stress
- ✓ Defects
- ✓ Thickness
- ✓ Roughness
- ✓ Composition, interdiffusion, gradients
- ✓ Size, morphology, ordering
- ✓ How does it perform under real working conditions?  
→ Come to a synchrotron and perform in-situ experiments!



# Further reading

- Thin Film Analysis by X-Ray Scattering, by Mario Birkholz, 2006
- Surface Science Techniques
  - Chapter 6: Grazing incidence X-Ray diffraction by Osami Sakata and Masashi Nakamura
  - Chapter 7: X-Ray Reflectivity by Gibaud, Chebil and Beuvier
- Renaud, G., et al. (2009). "Probing surface and interface morphology with Grazing Incidence Small Angle X-Ray Scattering." Surface Science Reports **64(8)**: 255-380





# Acknowledgments



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